The background of the slide is a Cosmic Microwave Background (CMB) fluctuation map, showing a complex pattern of blue and orange/yellow spots representing temperature variations in the early universe.

# The Shape of CMB Focal Planes to Come

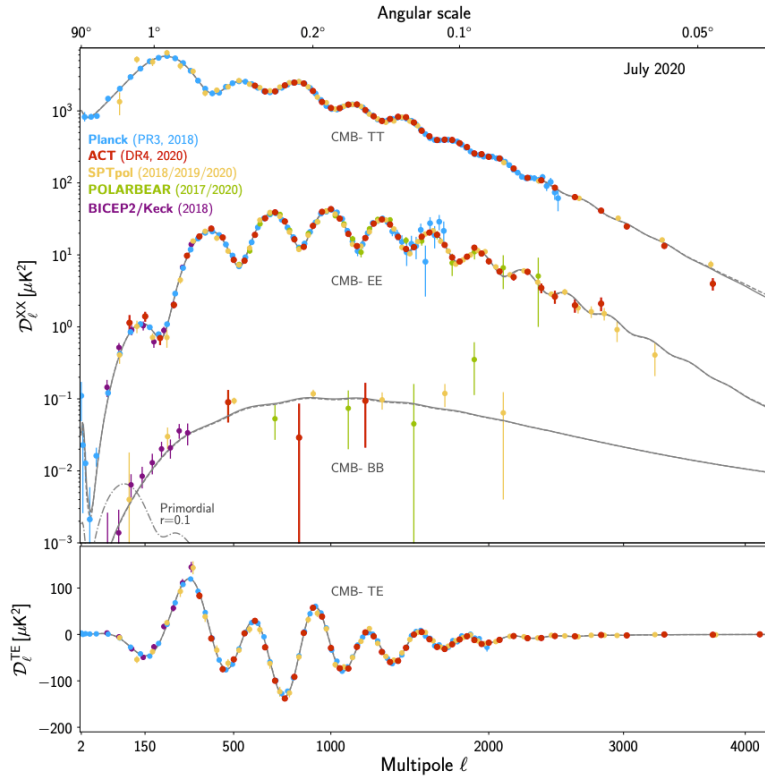
Johannes Hubmayr

Quantum Sensors Group, National Institute of Standards and  
Technology

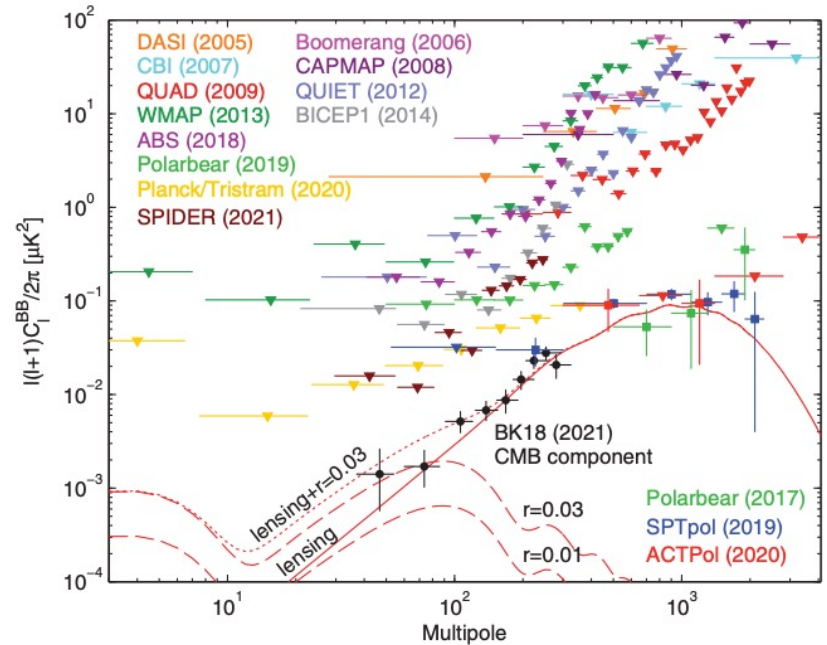
From Planck to the Future of CMB

Monday May 23, 2022

# Precision Cosmology Enabled by Sensor Array Developments



Steve K. Choi *et al* JCAP12(2020)045



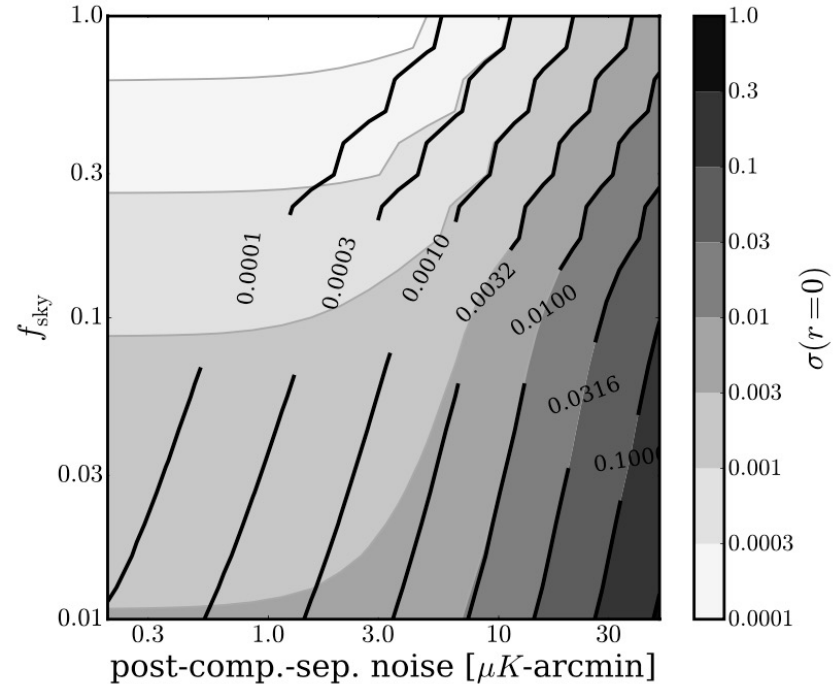
PHYSICAL REVIEW LETTERS 127, 151301 (2021)

# Single detector observation time to reach current $r$ limits

$$T_{obs} = \left( \frac{NET_{cmb}}{map\ depth} \right)^2 \frac{f_{sky}}{\eta}$$

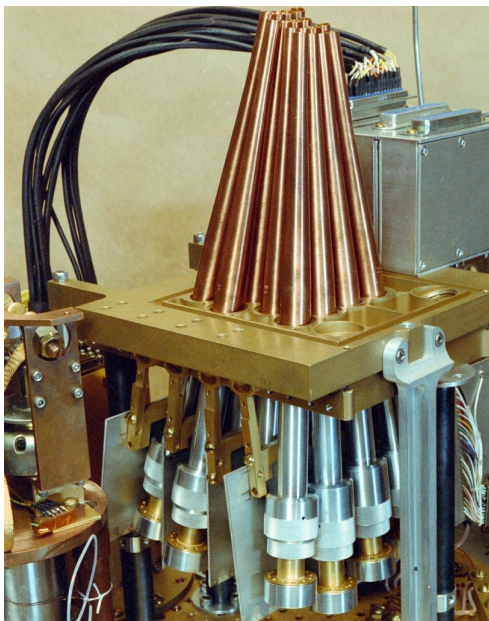
$r < 0.036 @ 2\sigma$  (BK18)  $\rightarrow$   
 $f_{sky} = 0.1$ , map depth = 20  
uK-arcmin,  $\eta=1$

Detector	$NET_{cmb}$	$T_{obs}$ (yrs)
Noiseless detector	27 uK $\sqrt{s}$	0.9
Space	40 uK $\sqrt{s}$	1.9
Ground	200 uK $\sqrt{s}$	47

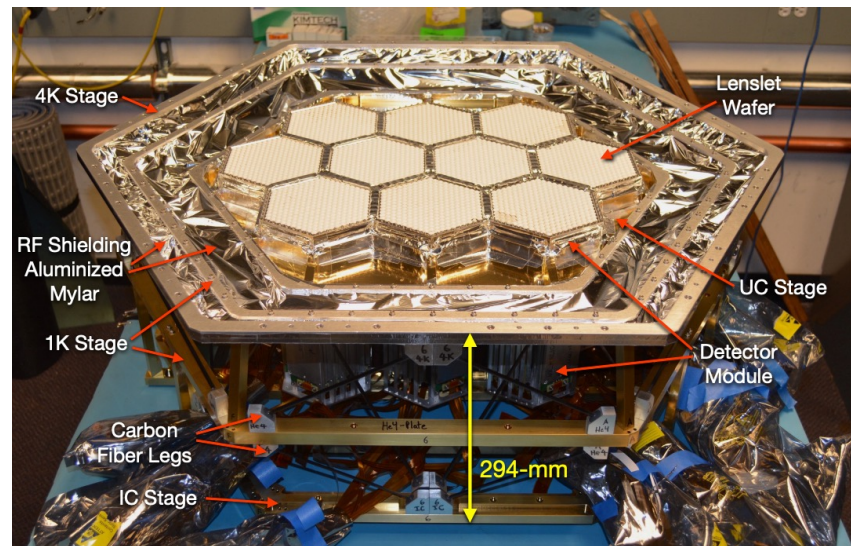


J. Errard et al. JCAP03(2016)052

# Focal Planes Past and Present



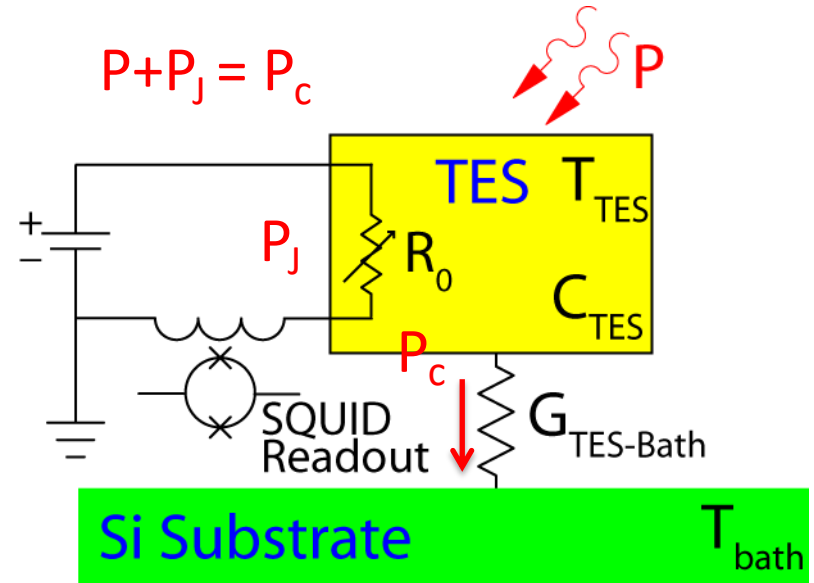
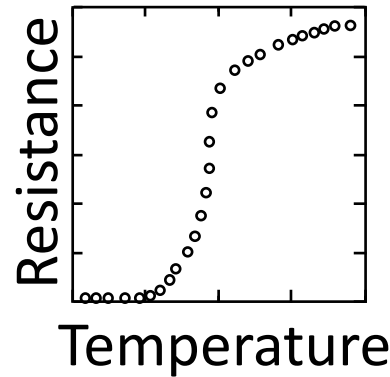
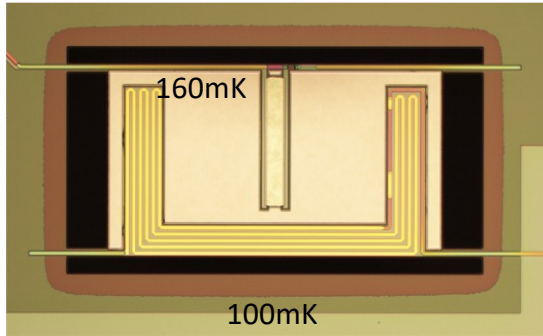
B. Rabi et al *Rev Sci Inst* **77**, 071101 (2006)



J. A. Sobrin et al 2022 *ApJS* **258** 42

*Trend: more sensors, more on-chip capability*

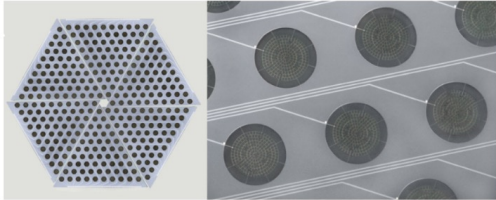
# Transition Edge Sensor (TES) bolometer



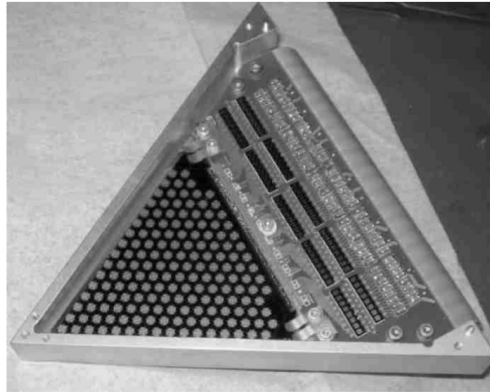
Credit: Doug Bennett

- Relative power meter that works by principle of electrical substitution
- Noise of device less than photon noise ( $NEP^2 = 2h\nu P$  for narrow band signal)
- TES may be fabricated in arrays
- Multiplexed Superconducting QUantum Interference Device (SQUID) readout

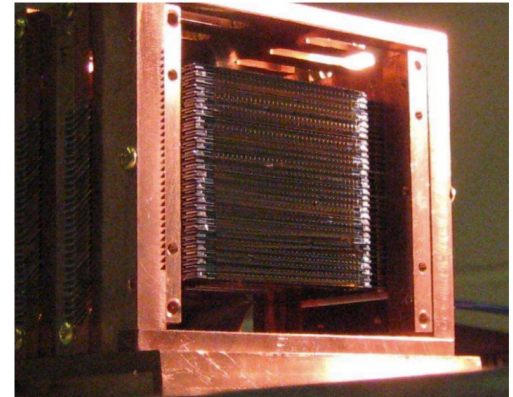
# Early CMB bolometer array examples



APEX-SZ (UC, Berkeley)

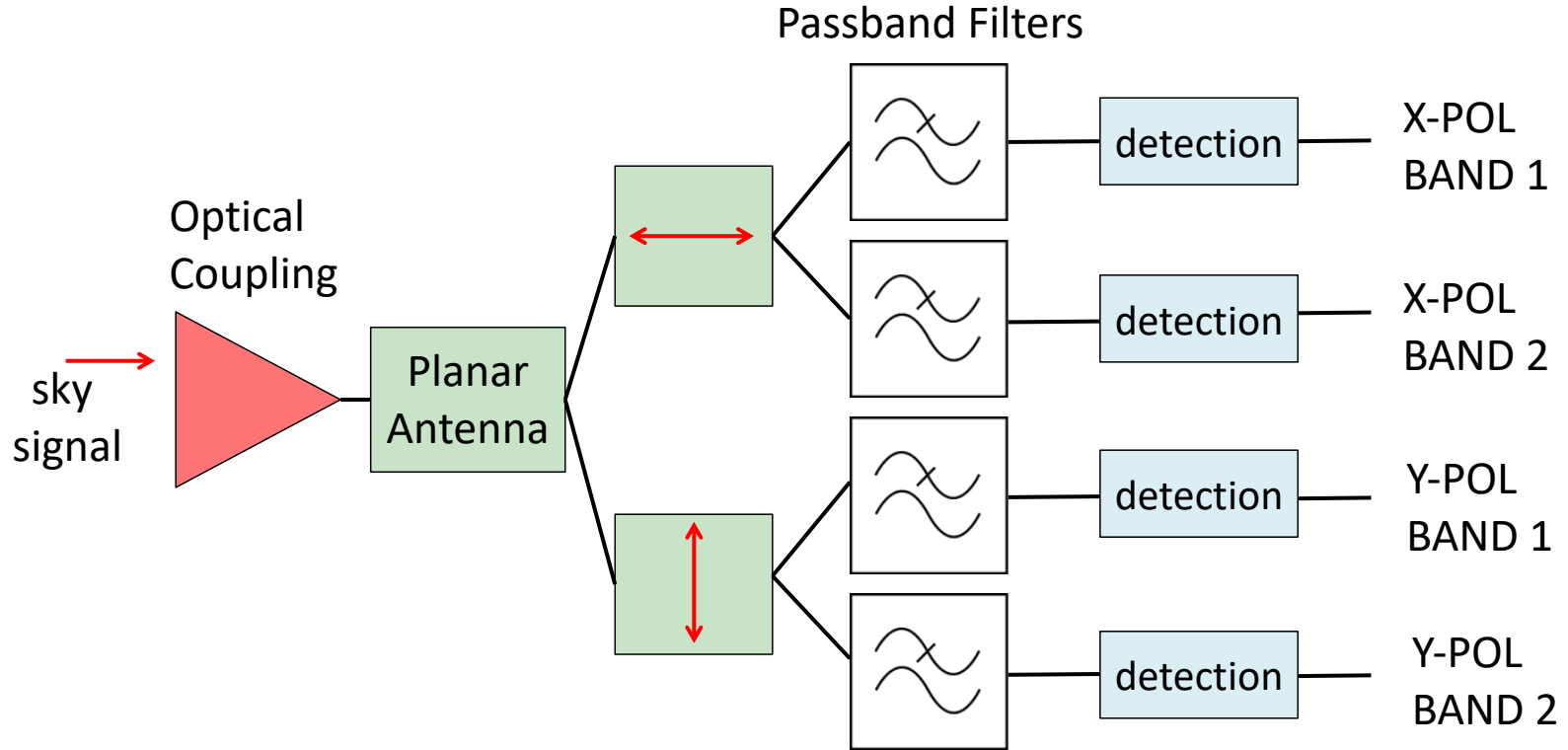


SPT wedge (UC, Berkeley)



ACT pop-up detectors (NASA, Goddard)

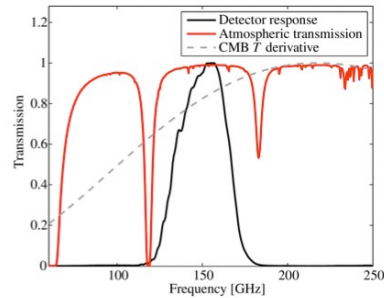
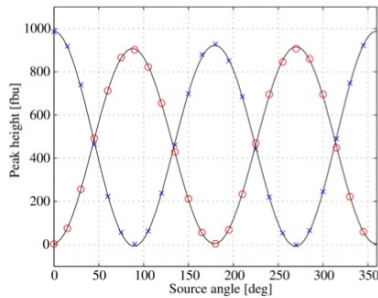
# Detection schematic



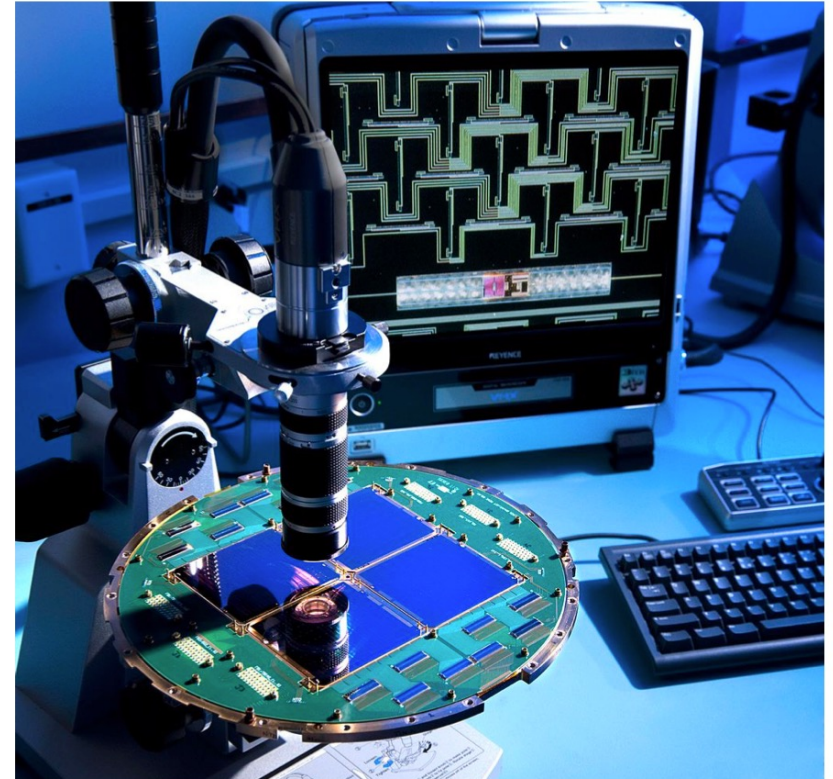
# Antenna-coupled TES arrays

## More on-wafer capability

- 1 Integrated optical coupling
- 2 Polarization sensitivity
- 3 on-chip passband definition



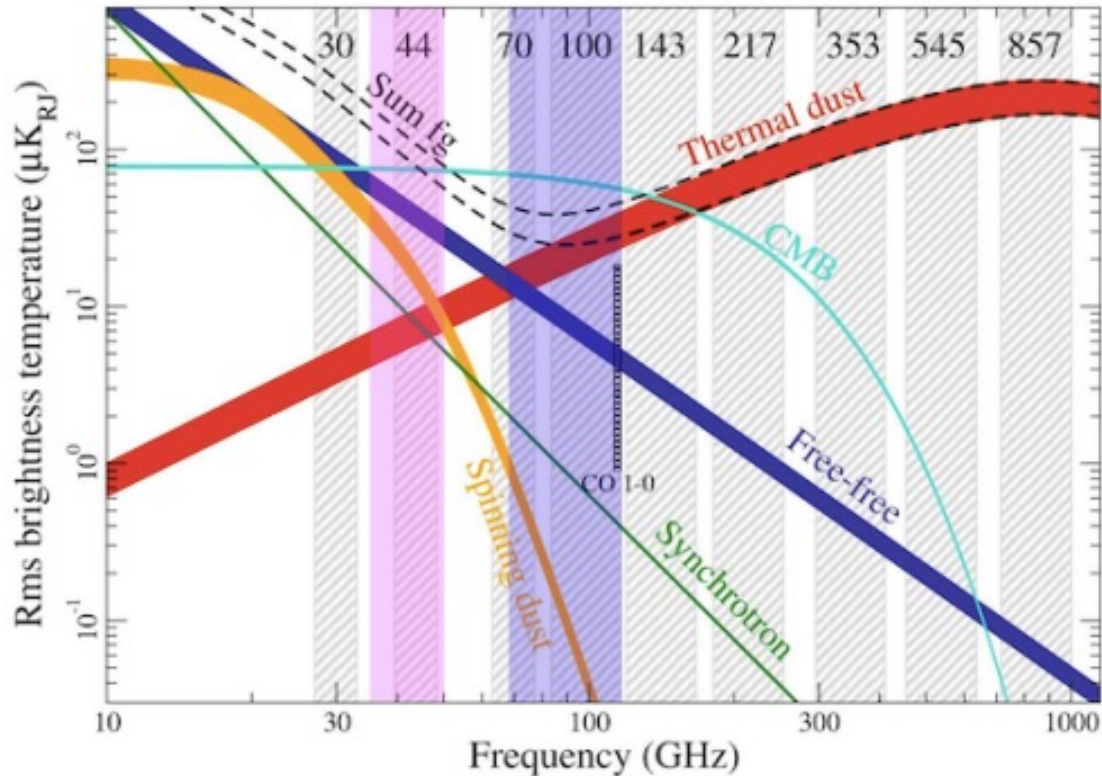
ApJ 792, 62, 2014



BICEP2 focal plane (Caltech/JPL)



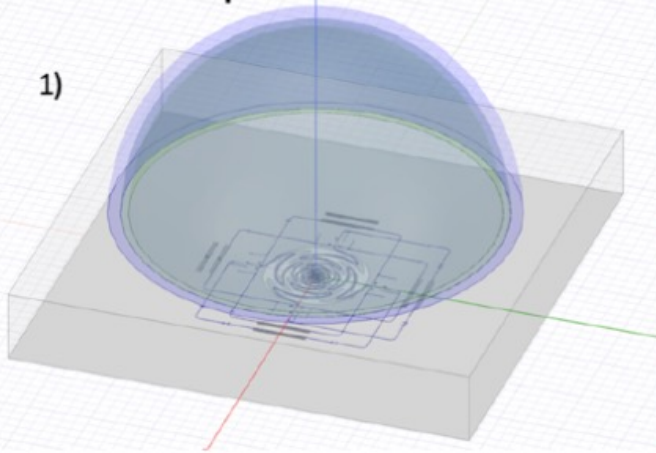
# Frequency Coverage -> Multichroic Detectors



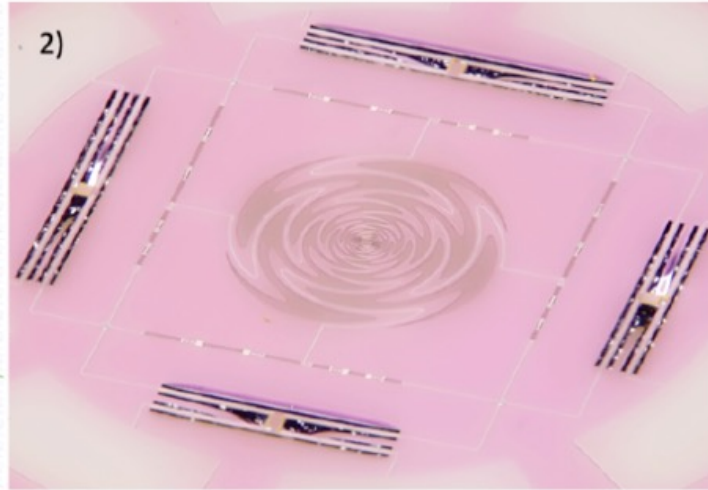
# Lenslet-coupled TES arrays

## Lenslet-coupled Detectors

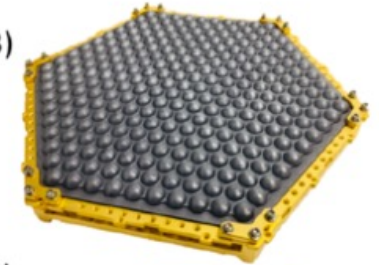
1)



2)



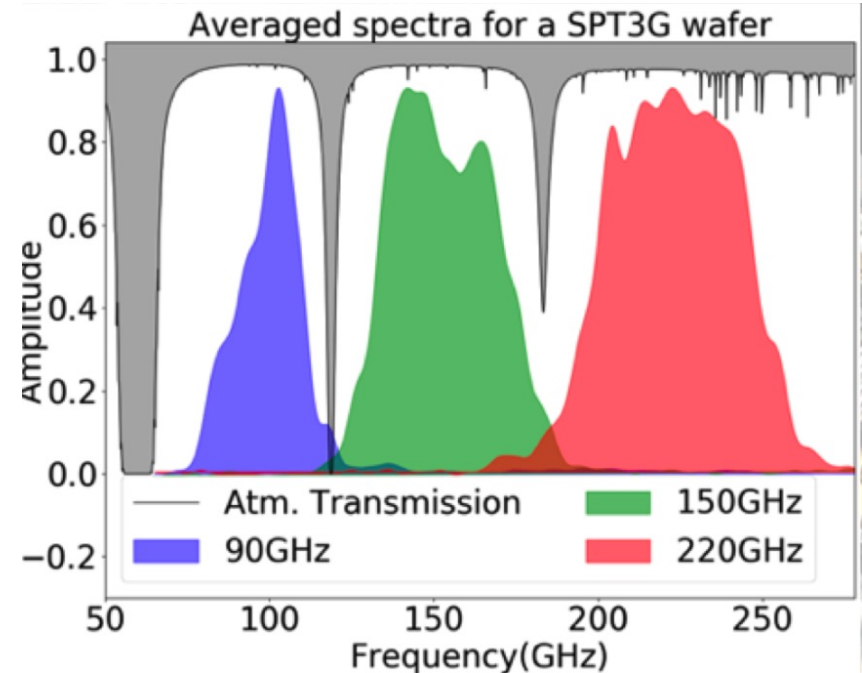
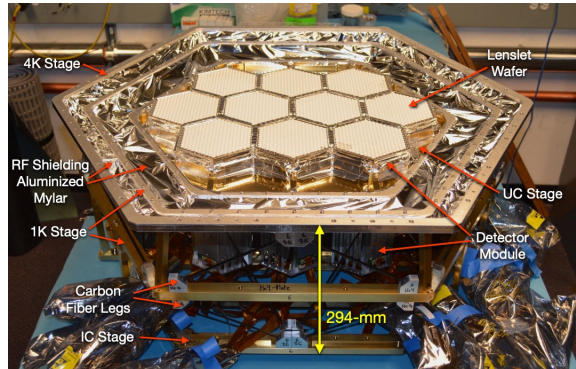
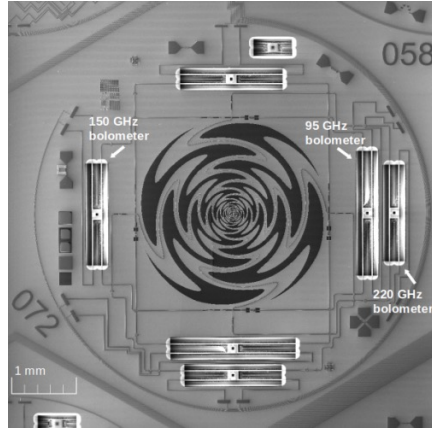
3)



4)



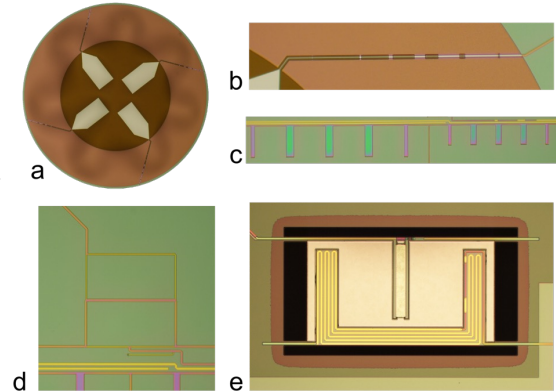
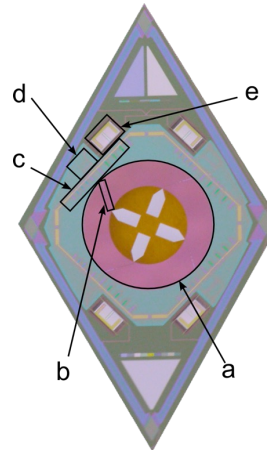
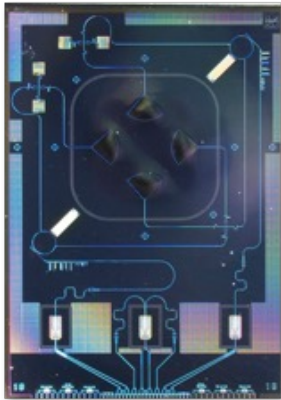
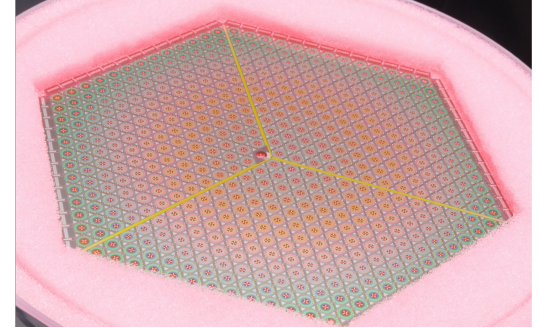
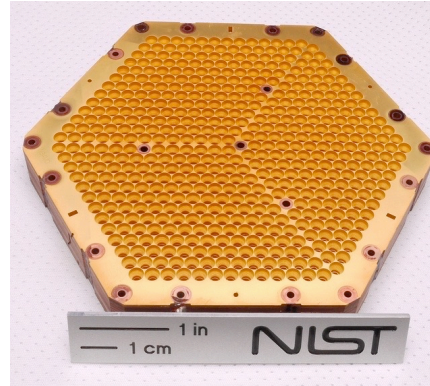
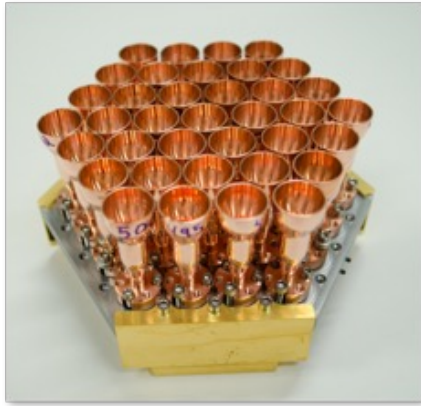
# Sinuuous antenna 3:1 bandwidth



Anderson et al 2018

# Feedhorn/OMT-coupled

NASA/Goddard

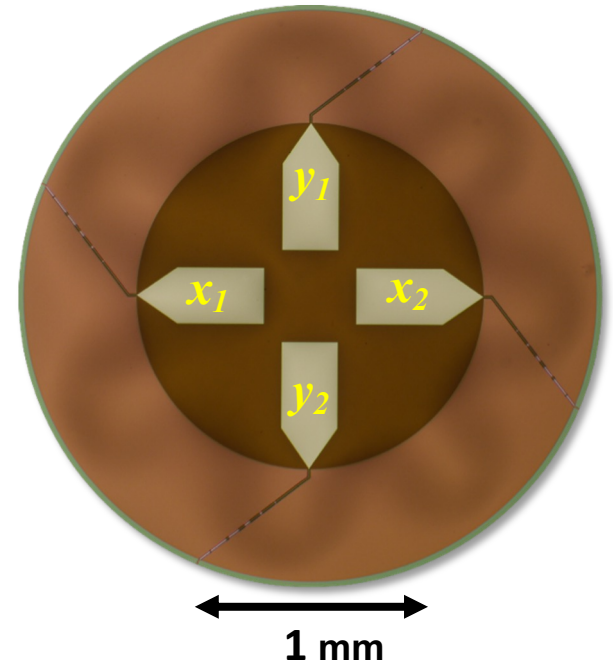
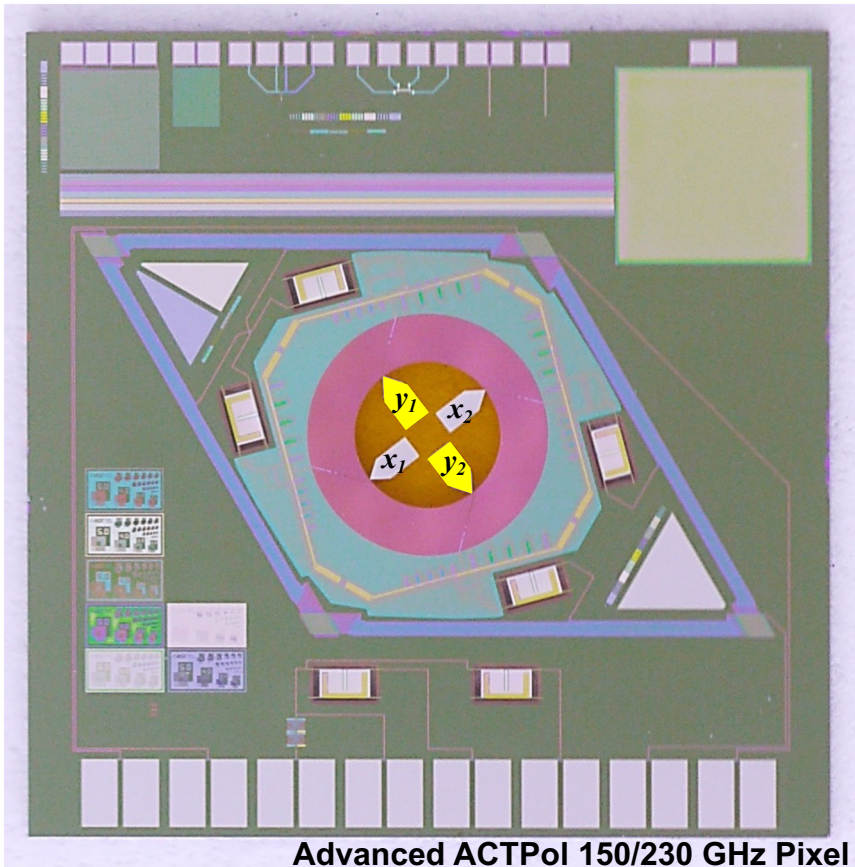


Duff et al 2016

# CMB polarimeter

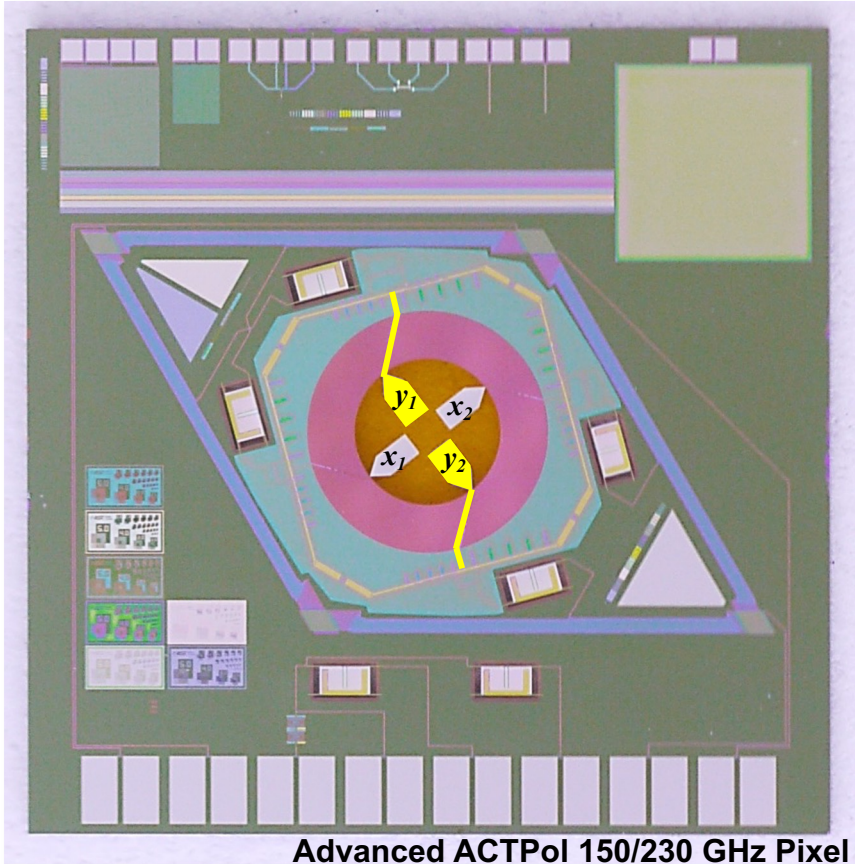
- Planar orthomode transducer (OMT) separates x & y linear polarizations

8.5 mm

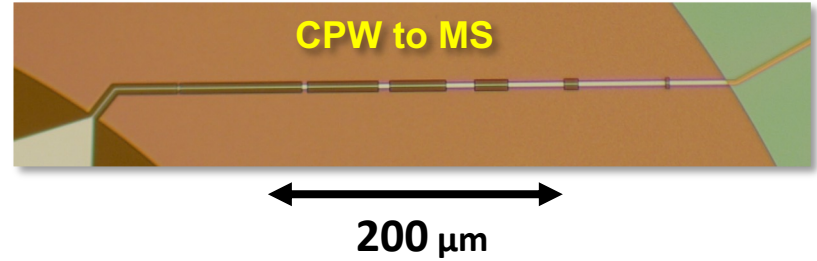


# CMB polarimeter

8.5 mm

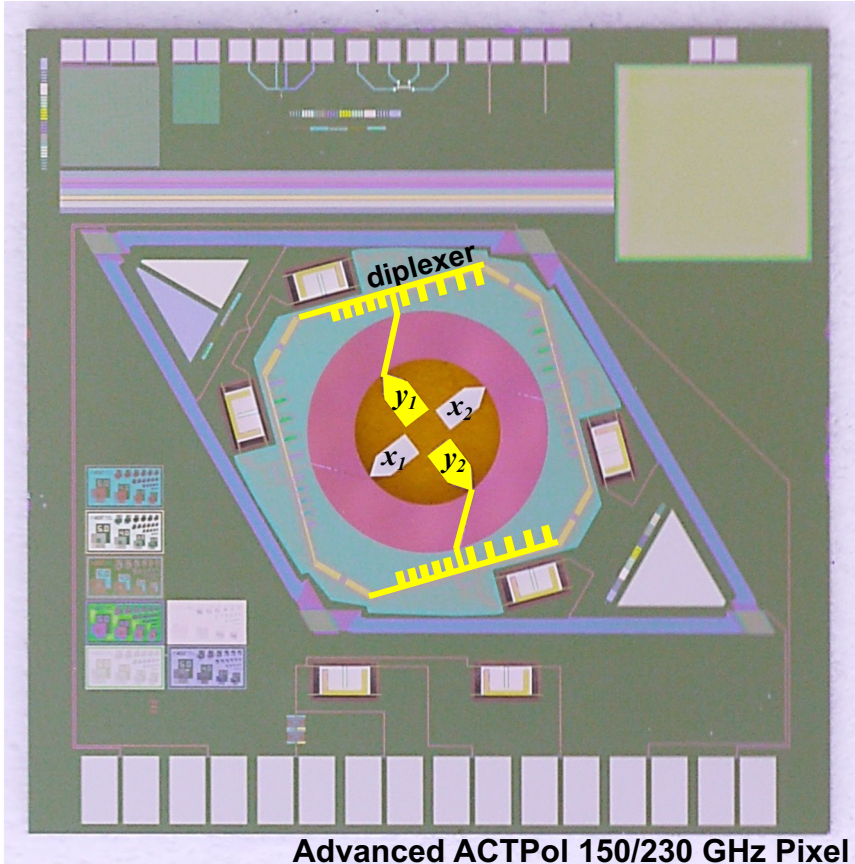


- Planar orthomode transducer (OMT) separates x & y linear polarizations
- CPW to MS transition

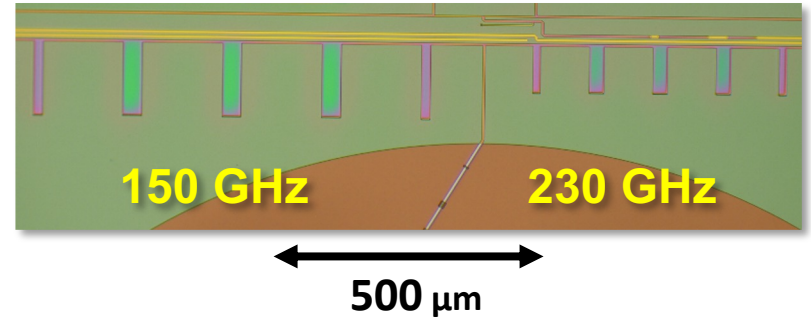


# CMB polarimeter

8.5 mm

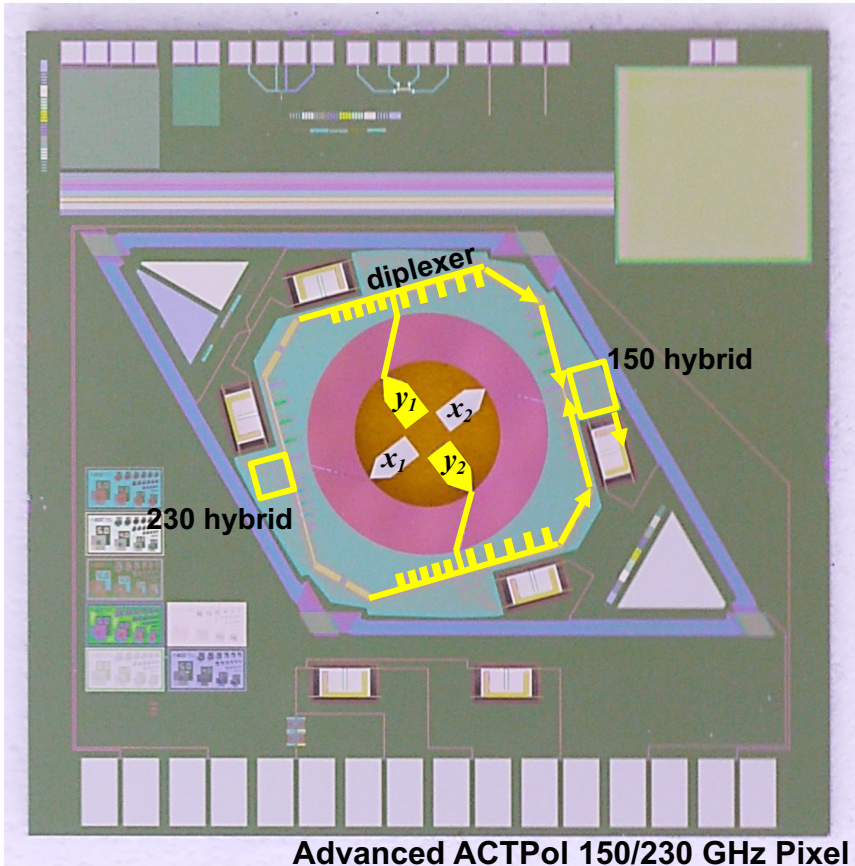


- Planar orthomode transducer (OMT) separates x & y linear polarizations
- CPW to MS transition
- Filter into two bands

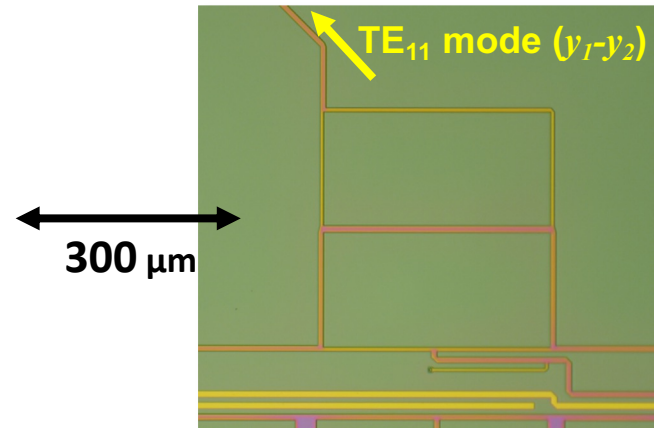


# CMB polarimeter

8.5 mm

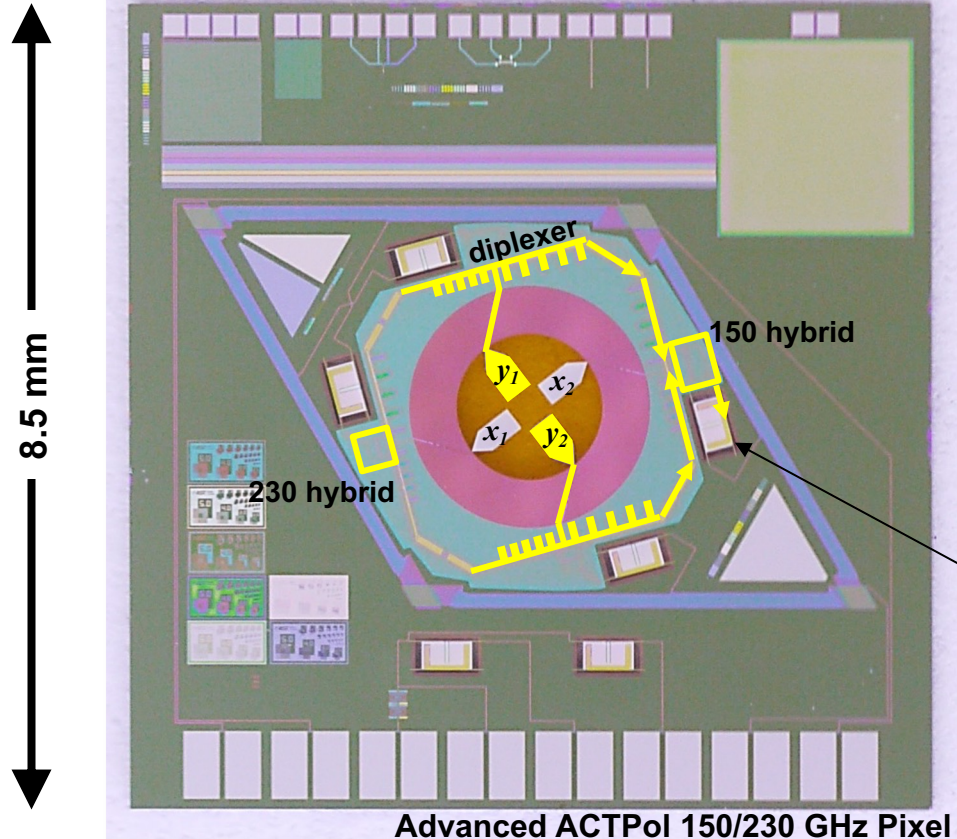


- Planar orthomode transducer (OMT) separates x & y linear polarizations
- CPW to MS transition
- Filter into two bands
- Combine lowest order mode/  
reject others

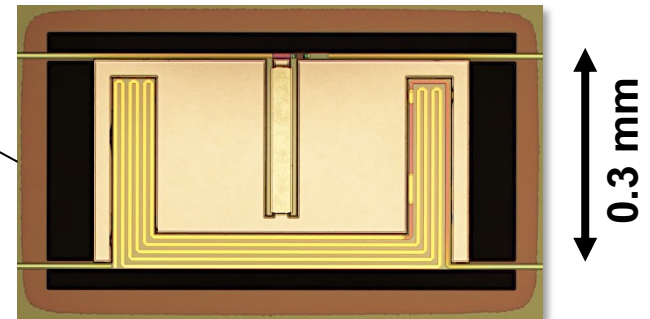




# CMB polarimeter



- Planar orthomode transducer (OMT) separates x & y linear polarizations
- CPW to MS transition
- Filter into two bands
- Combine lowest order mode/reject others
- Power sensed with TES bolometer



# Detector technology for active/planned experiments

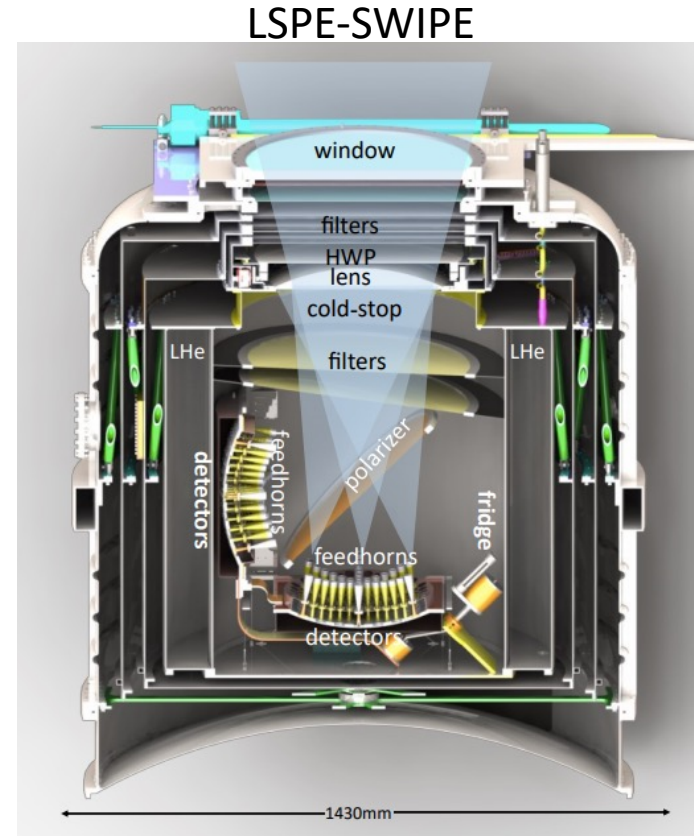
Detector type	Deployed	Planned/in-development
Antenna	BICEP2, SPIDER, KECK, BICEP3, BICEP Array	BICEP Array
Lenslet	Polarbear, PB2/Simons Array, SPT-3G, GroundBIRD	Simons Observatory, LiteBIRD, GroundBIRD
Feedhorn/planar OMT	ABS, SPTpol, ACTPol, Advanced ACTPol, CLASS, GroundBIRD	AliCPT, Simons Observatory, LiteBIRD, Taurus, CMBS4
direct absorber	PIPER, LSPE/SWIPE*	QUBIC**
coherent	QUIJOTE, LSPE/STRIP	

\*with multi-moded feed-coupling

\*\* with switching horn array

# Need more light, not necessarily more detectors

- 326 spider-web TES bolometers
- 8800 EM modes
- More modes -> decreased angular resolution

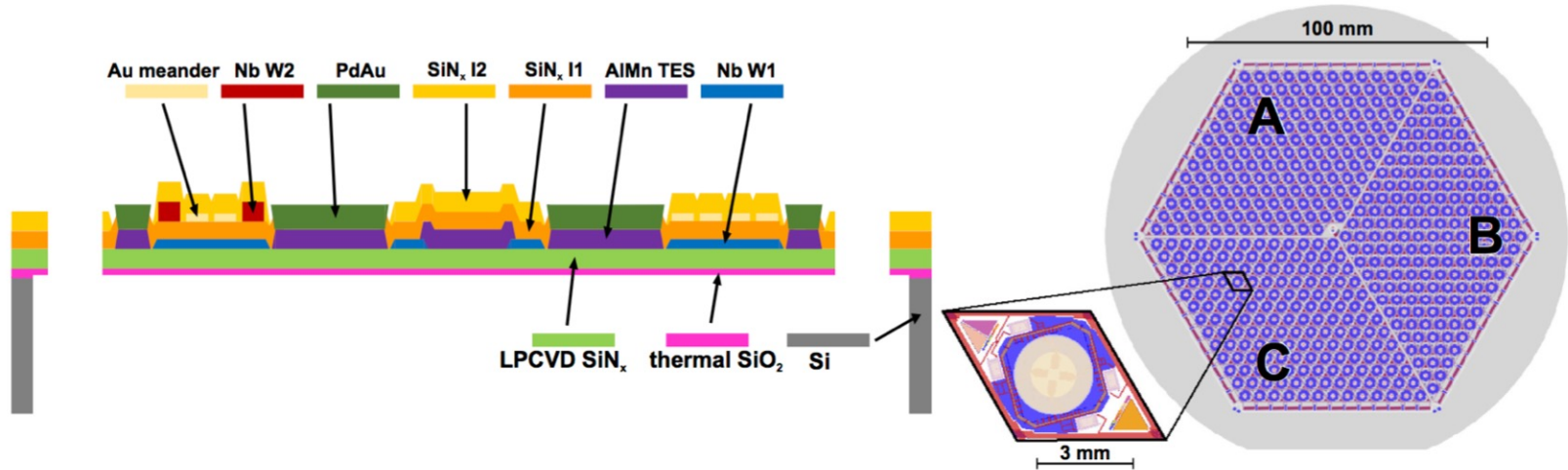


Addamo et al. JCAP 2021

# Advances enabled by microfab



# OMT-coupled fabrication process

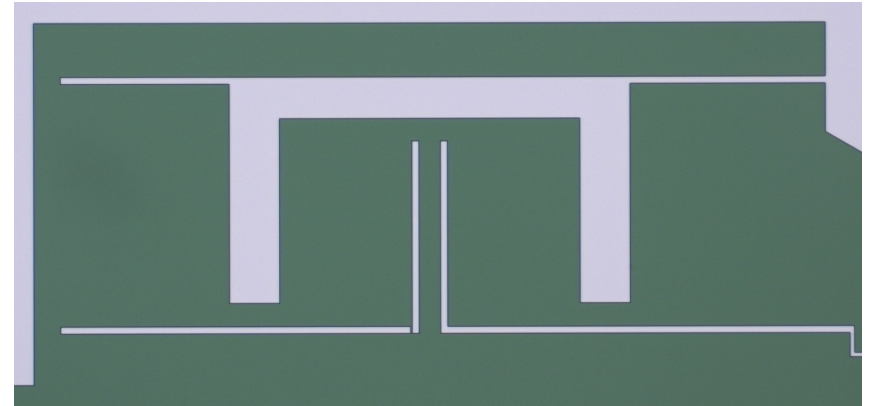


[Duff et al. JLTP 184 \(2016\)](#)

- 7 lithography levels
- Four metals, three dielectrics
- 10+ fabrication steps

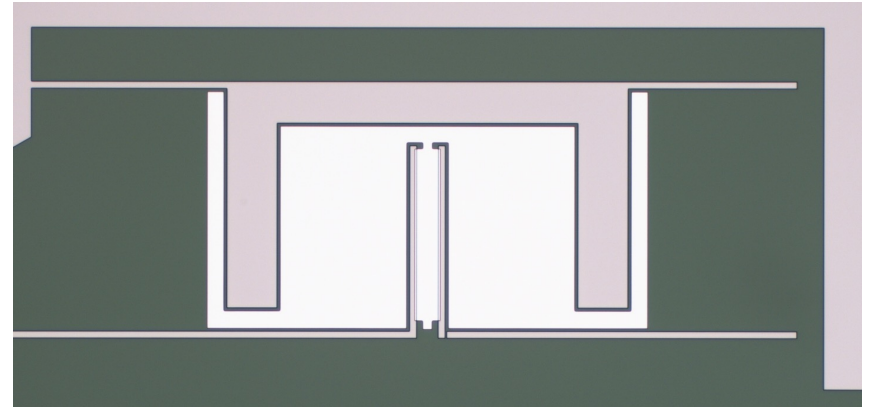
# TES bolometer fabrication process

1.  $\text{SiO}_x + \text{SiN}$
2. 1<sup>st</sup> Nb layer
3. TES
4. 1<sup>st</sup> insulator layer
5. 2<sup>nd</sup> Nb layer
6. Au term resistor
7. 2<sup>nd</sup> insulator layer
8. PdAu
9. FSP (thermal isolation definition)
10. Deep Etch



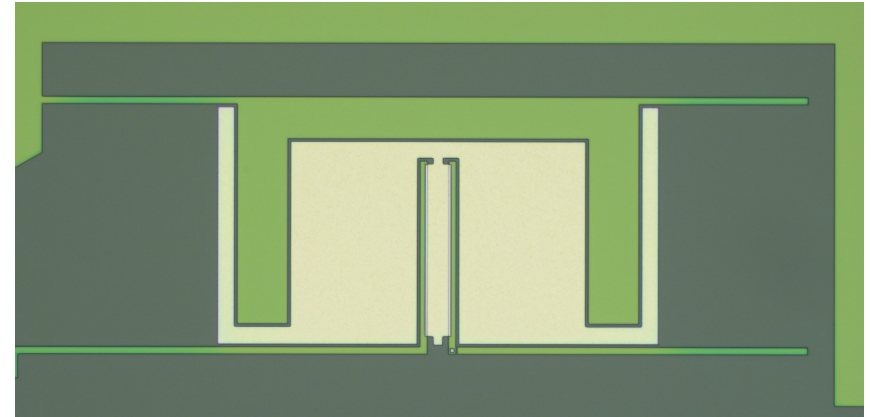
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# TES bolometer fabrication process

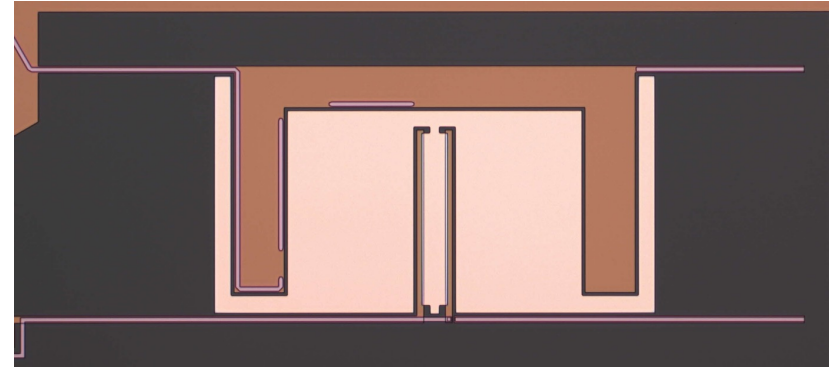
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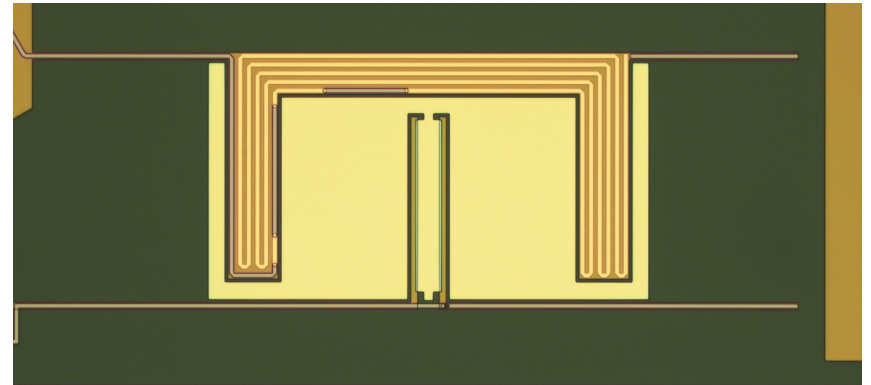
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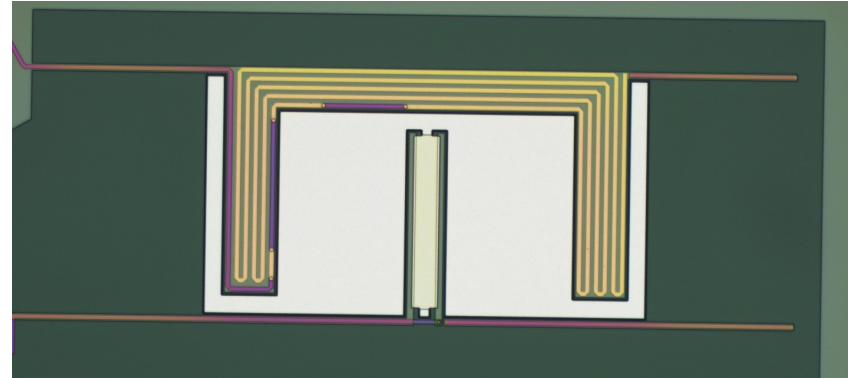
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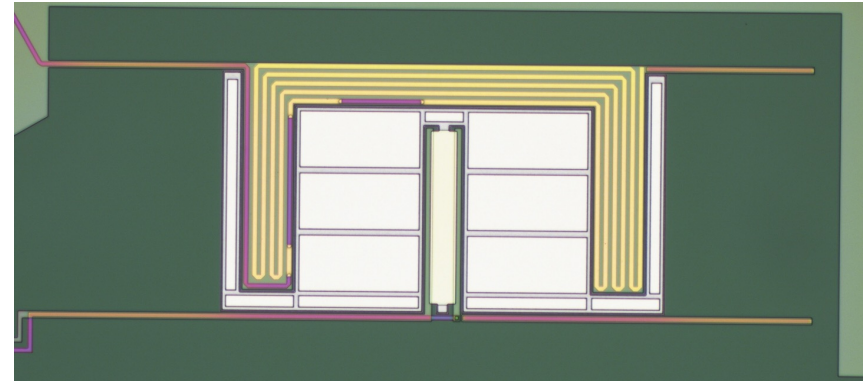
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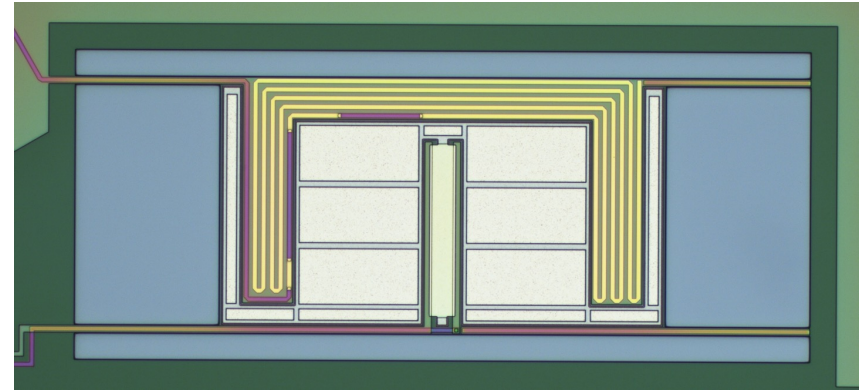
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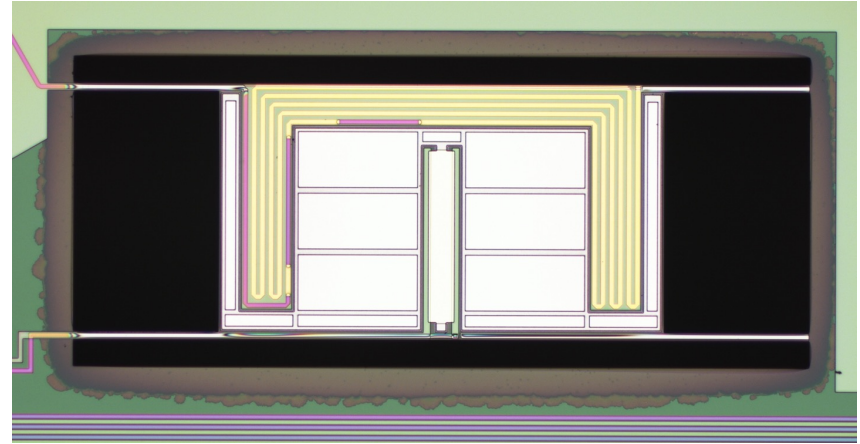
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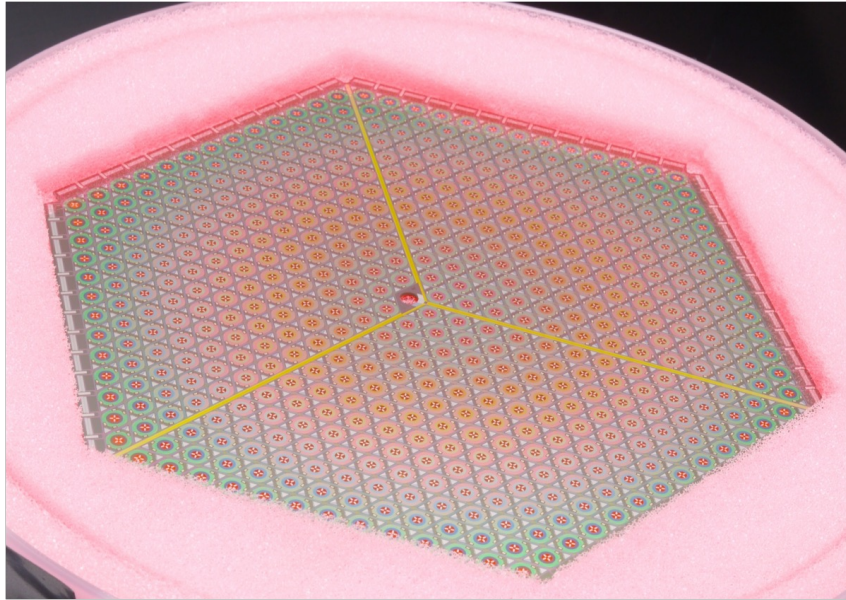


# TES bolometer fabrication process

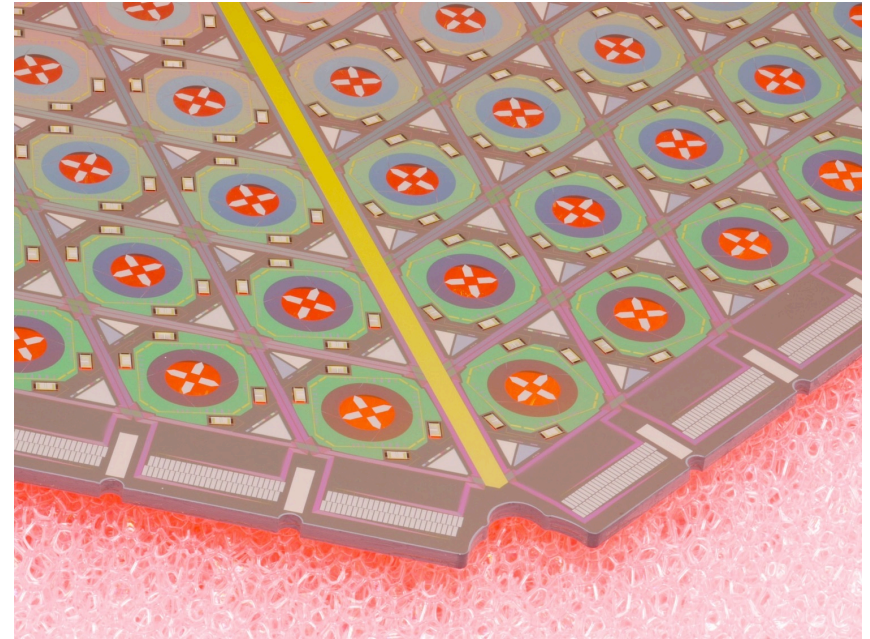
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8. PdAu
9. FSP (thermal isolation definition)
10. Deep Etch



# Completed Array



506 spatial pixel



unit cell size = 4.75mm

# Superconducting IC array performance

Antenna-coupled TES Bolometers used in BICEP2, Keck Array, and SPIDER  
*The BICEP2, Keck Array, and SPIDER Collaborations, ApJ 812, 176, 2015*

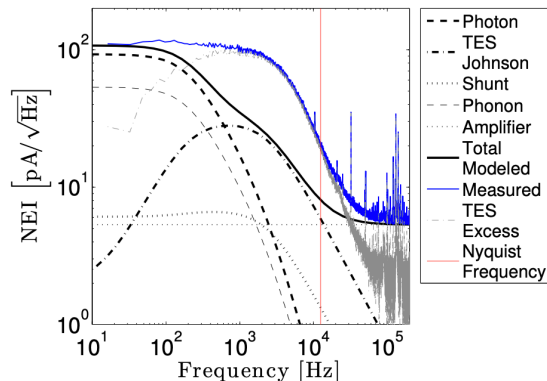
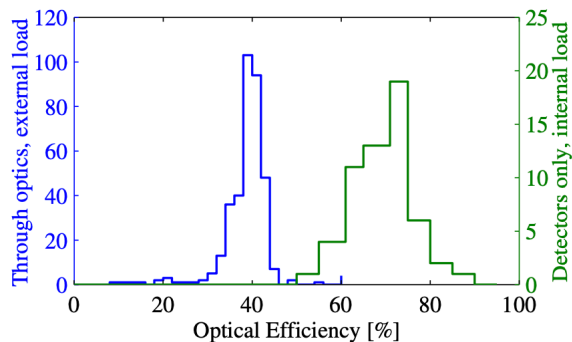
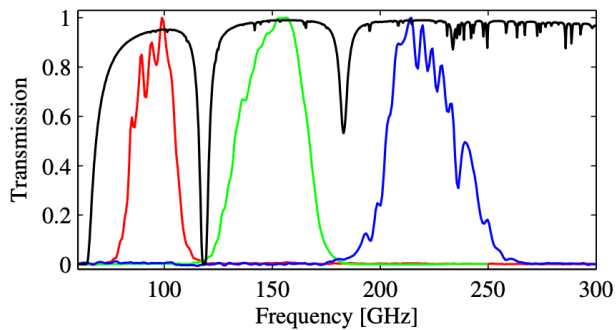


FIG. 20.— Measured and modeled noise for a single detector in the Keck Array. The red line indicates the Nyquist frequency for the multiplexing rate.

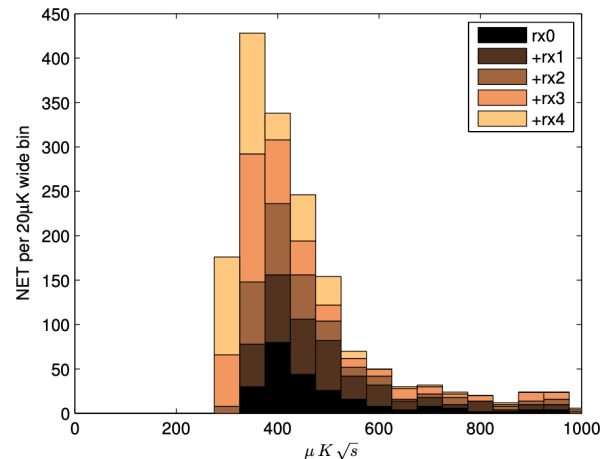
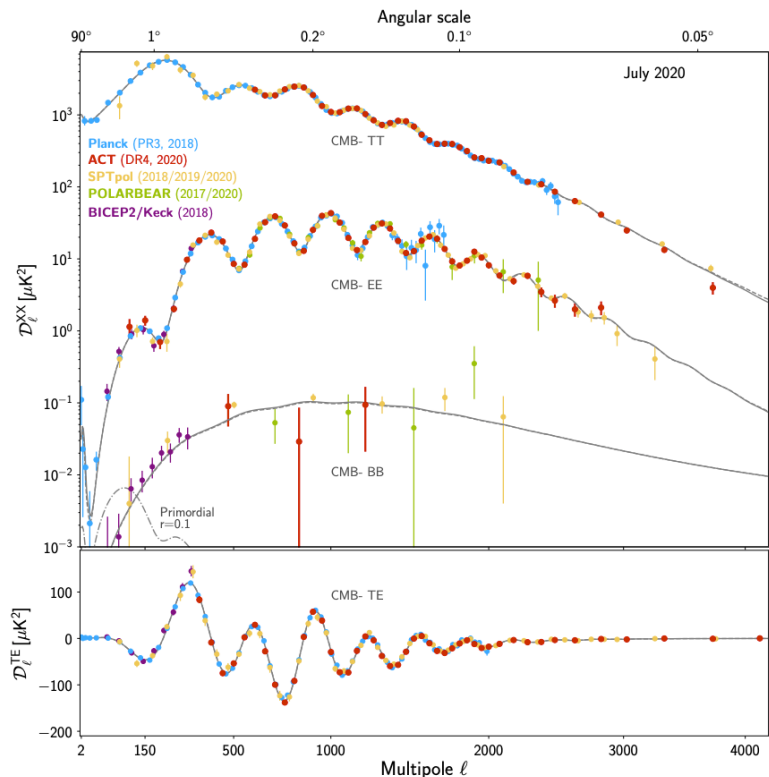


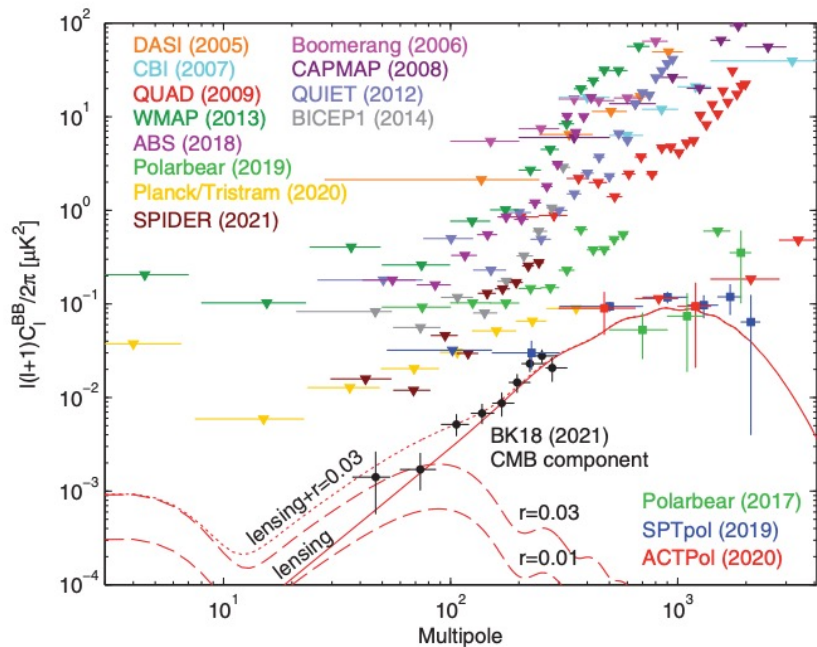
FIG. 21.— NET per detector histogram for the Keck Array in 2013



# Superconducting IC array performance



Steve K. Choi *et al* JCAP12(2020)045

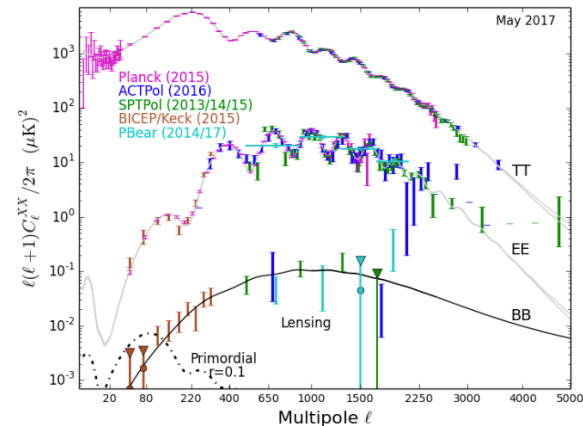


PHYSICAL REVIEW LETTERS 127, 151301 (2021)

# Conclusions slide from 5 yrs ago still correct?

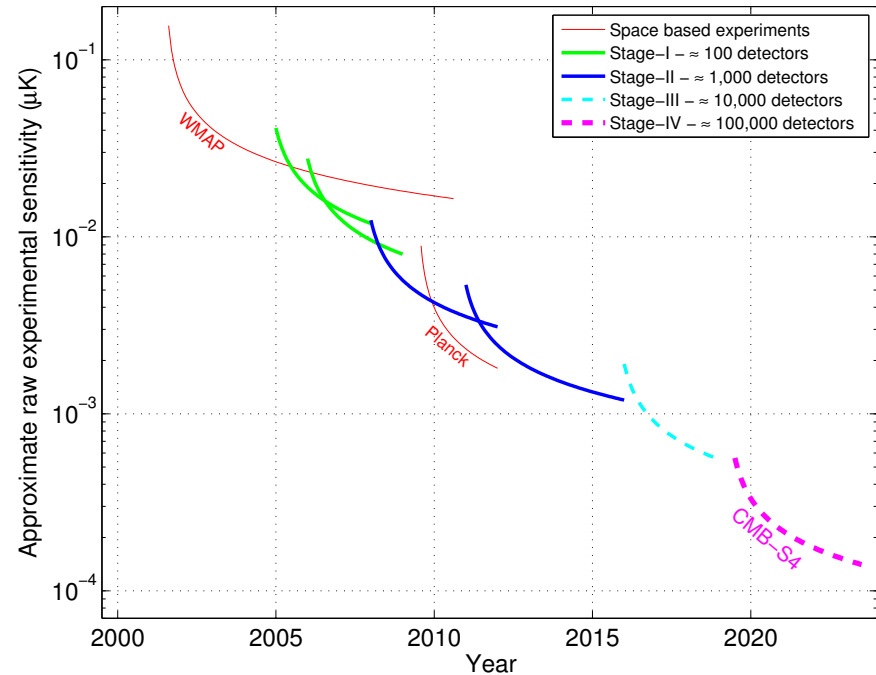
## Final Thoughts

- 1 Wave of excitement and activity in CMB research has not yet crested. CMB is the gift that keeps on giving.
- 2 Detector community has realized many aspects of the 'ideal detector array'
- 3 Increased quantity of existing detector technology meets the needs of next-generation experiments (like CMB-S4)
- 4 CMB imagers will benefit most from innovations in readout and detector packaging. Detectors are in the bag!



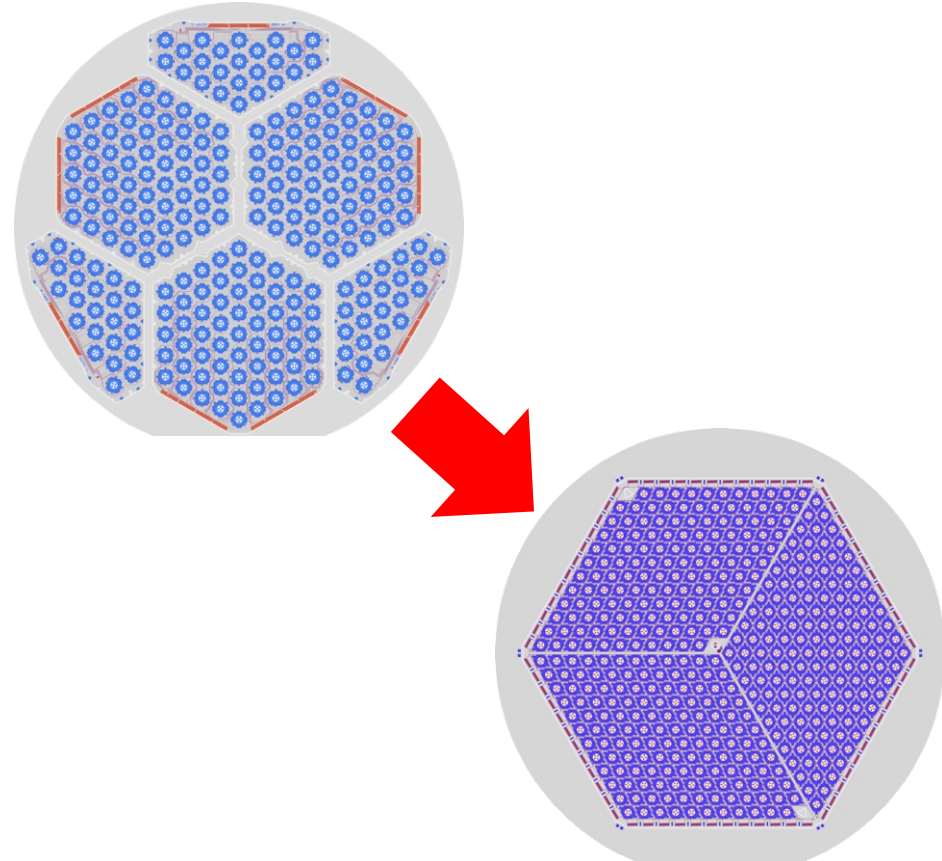
# Challenge #1: Detector Production

- CMB-S4 requires 0.5M sensors, 500 wafers, 9m<sup>2</sup> of silicon!
- This is x10 larger than what has been produced and deployed to date.



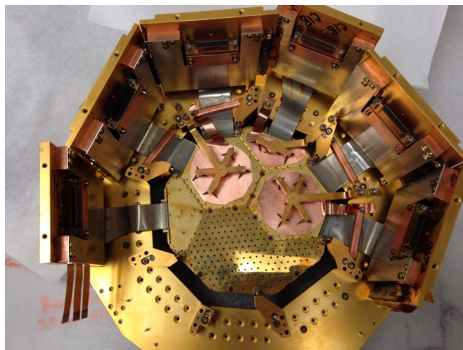
# Increased wafer size: 150mm

- Increased wafer size a common industry approach to increase throughput / decrease cost
- 150mm substrates now state of the art for CMB sensor array fabrication

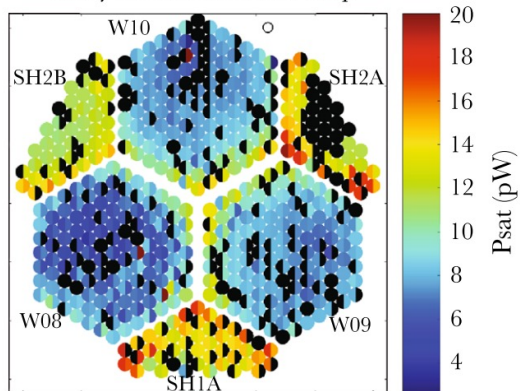


# Improved uniformity and repeatability

Previous generation arrays

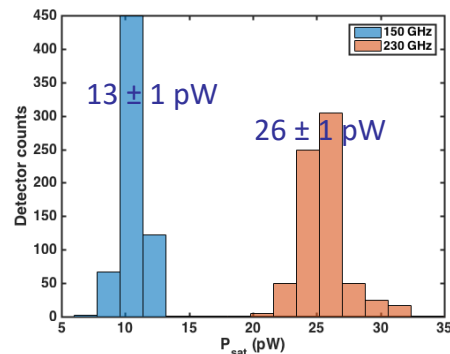
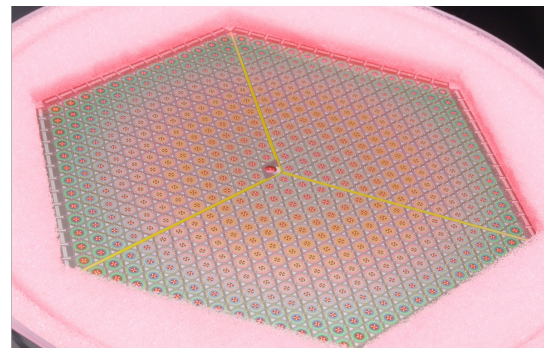


Array Saturation Power Map



[Grace et al JLTP 176 \(2014\)](#)

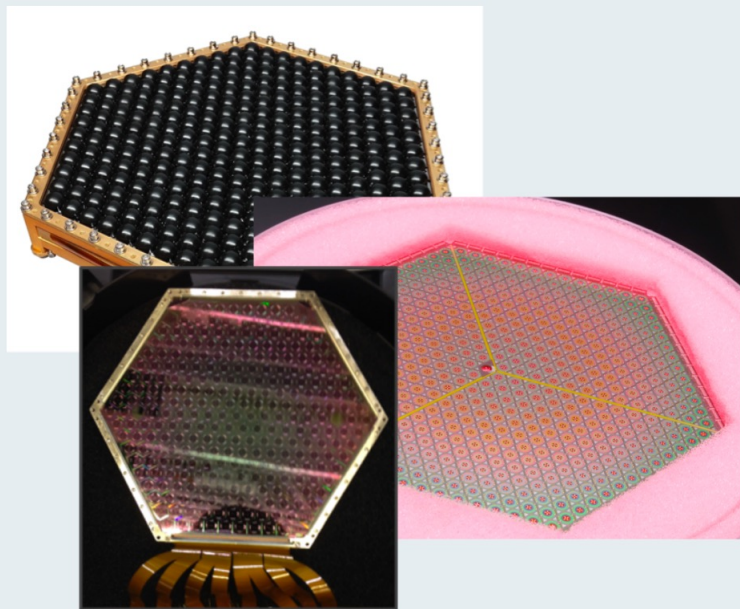
Current generation arrays



[Ho et al. SPIE 991418 \(2017\)](#)

# > 150 mm?

## 150 mm wafers

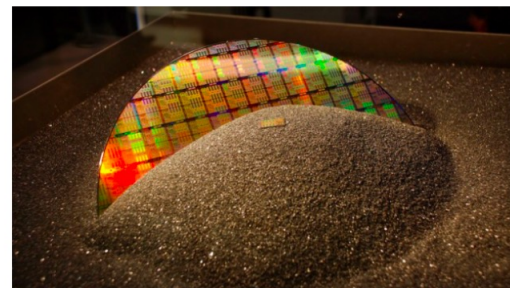


## Go bigger?

450mm silicon wafers aren't happening any time soon as major consortium collapses

By Joel Hruska on January 13, 2017 at 4:00 pm 30 Comments

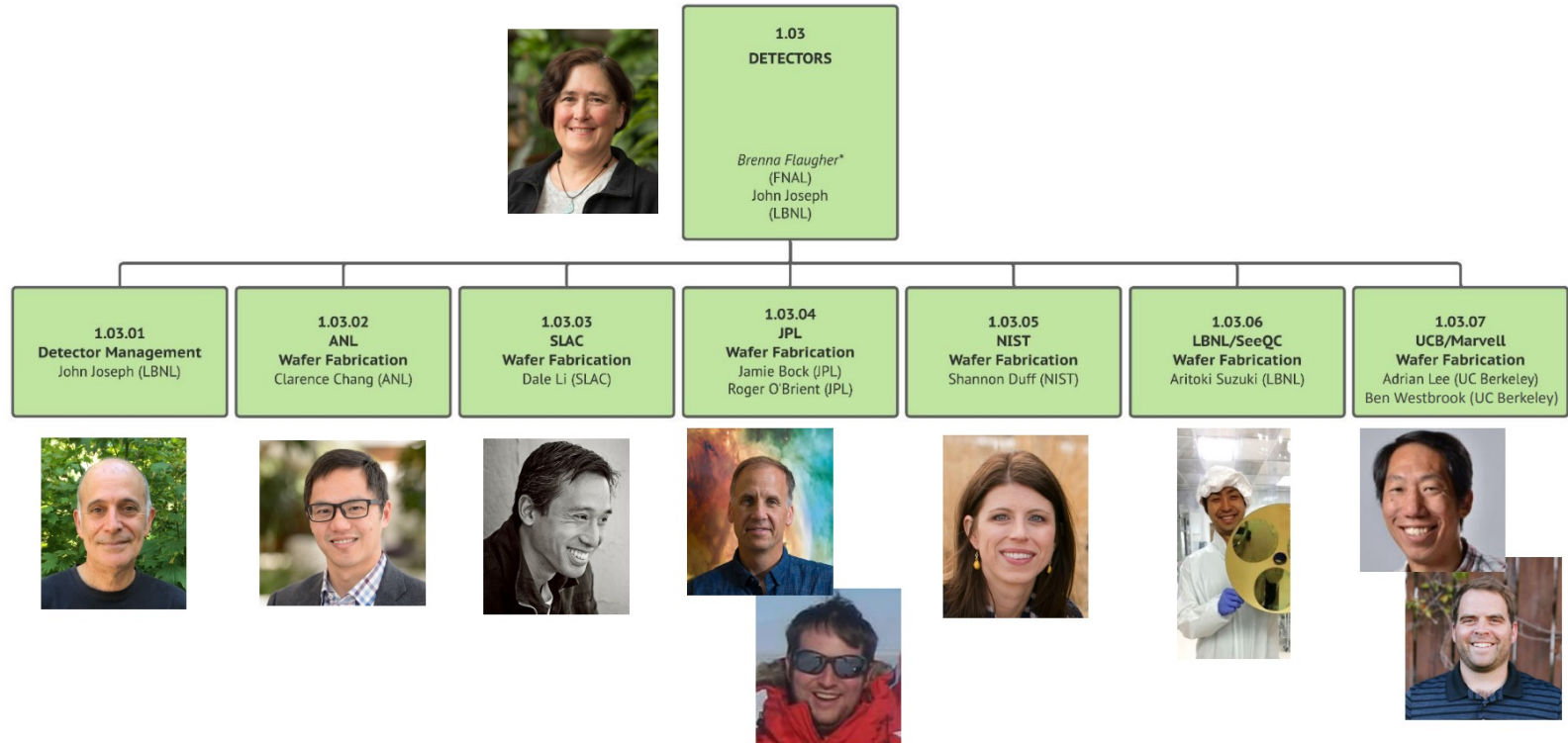
247  
shares



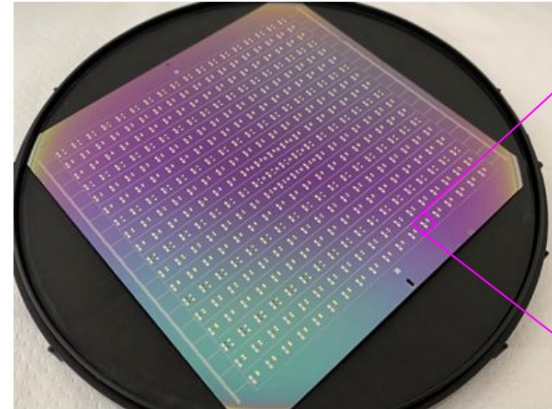
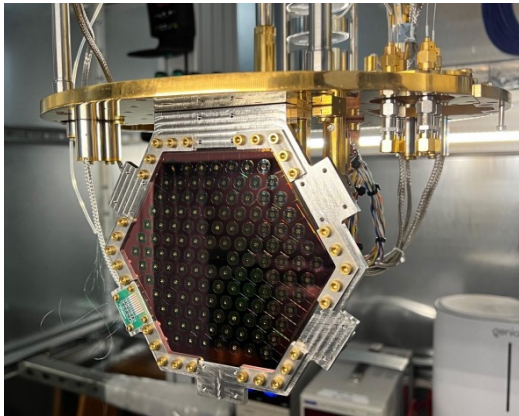
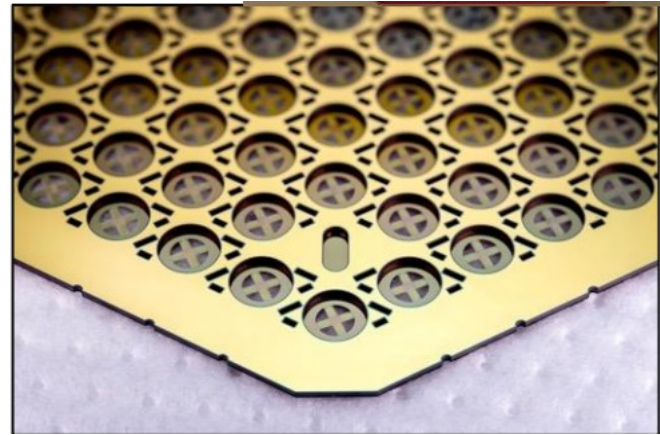
source: extremetech.com

- Cost prohibitive
- Quantity to produce too small

# Solution for CMB-S4: team-up!



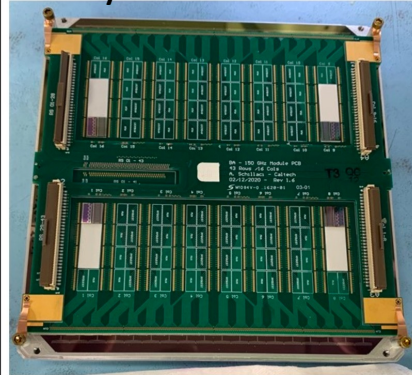
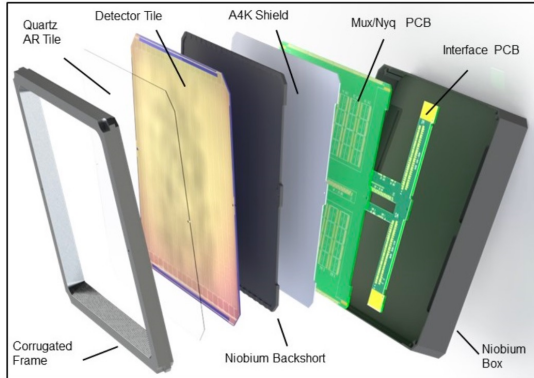
# Solution for CMB-S4: team-up!





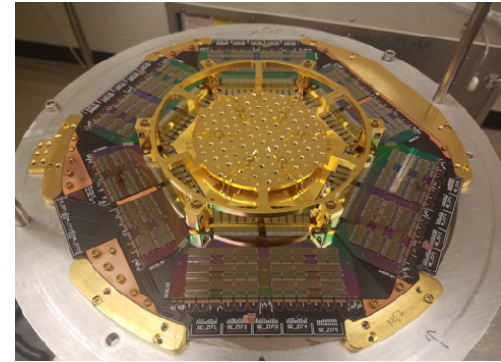
# Challenge #2: packaging

## BICEP array

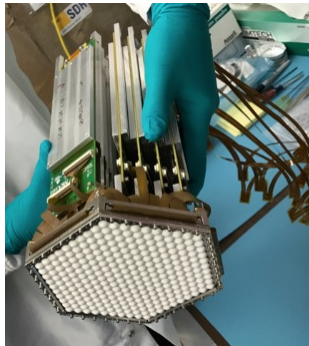


A. Schillaci 2022

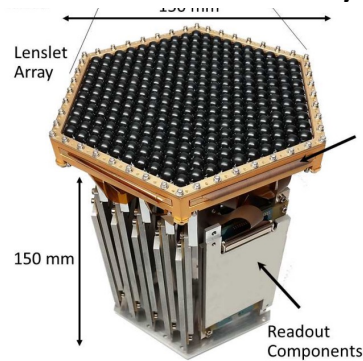
## Advanced ACTPol



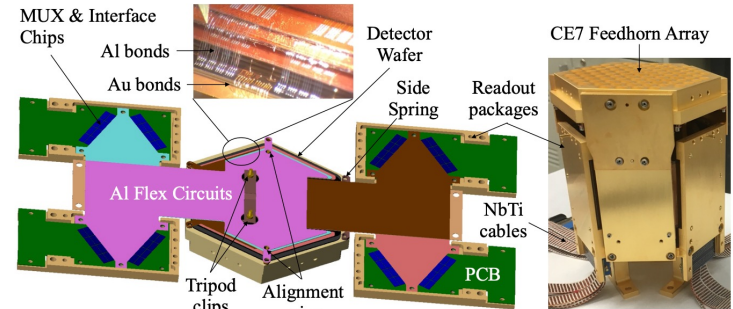
## SPT-3G



## PB2/Simons Array

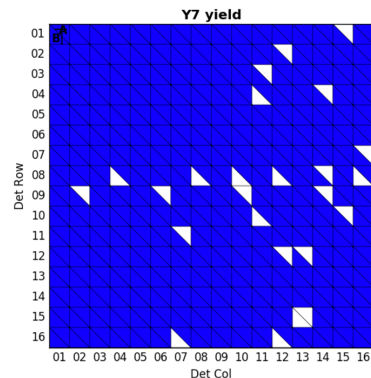
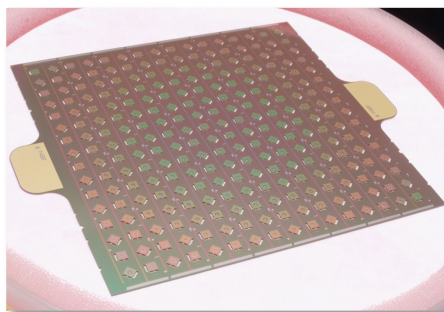
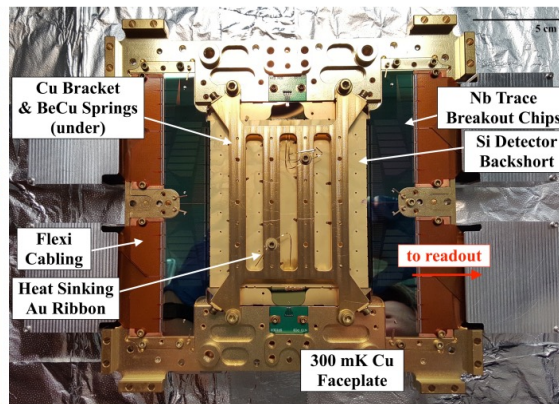
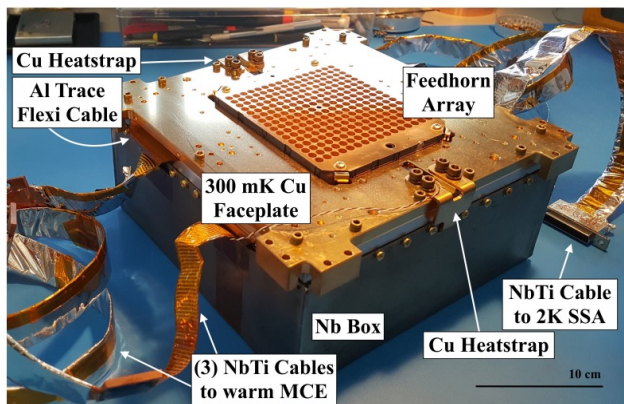


## CLASS



# SPIDER 280 GHz example

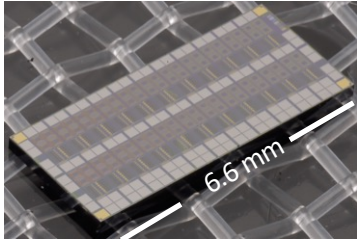
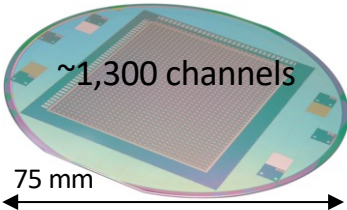
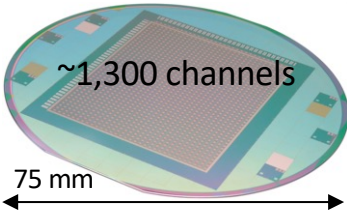
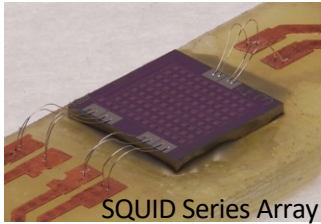
*SPIDER 280 GHz >95% end-to-end yield (defined by acquiring useable IV curves)*



Bergman et al 2018

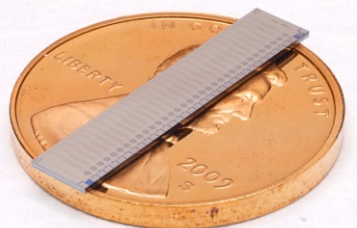
# SQUID multiplexers

Traditional SQUID multiplexing  
30,000 deployed pixels

1D mux	Time division MUX	2D mux	MHz frequency division MUX
			
ABS, ACT, ACTPol, AdvACT, BICEP2, BICEP3, CLASS, KECK Array, MUSTANG, SPIDER, ZEUS	HAWK+, PIPER, SCUBA2		APEX-SZ, EBEX, PolarBEAR, PolarBEAR2/Simons Array, SPT, SPTpol, SPT3G

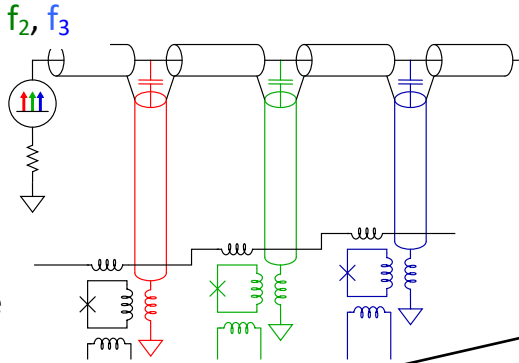
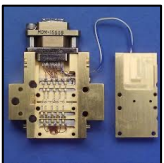
Microwave SQUID multiplexing

33-channel  $\mu$ MUX chip




a scalable architecture for the readout of large TES arrays

MUSTANG2, Simons Observatory

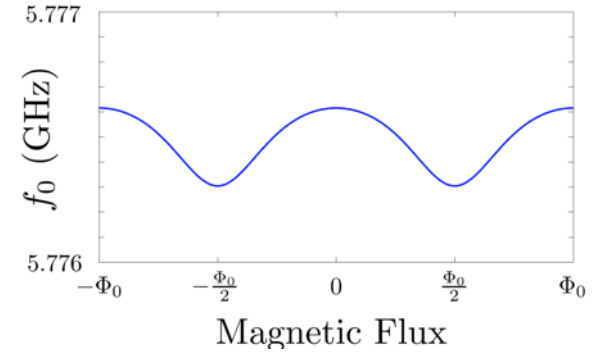
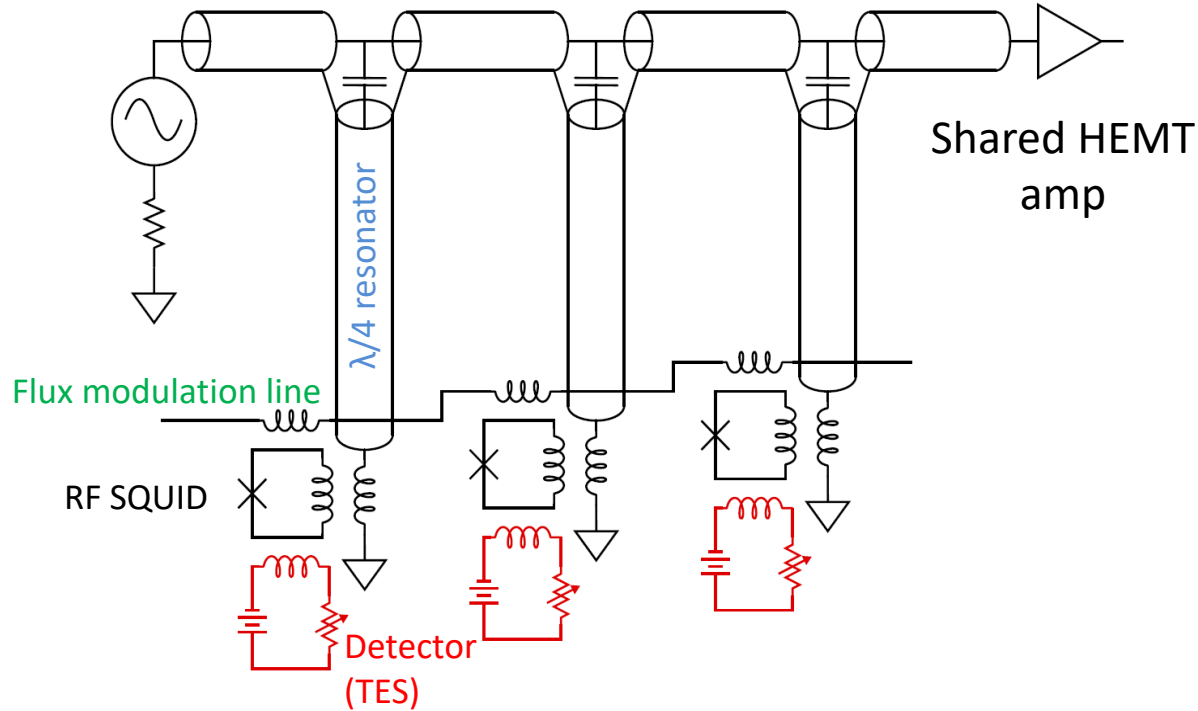



4K LNA

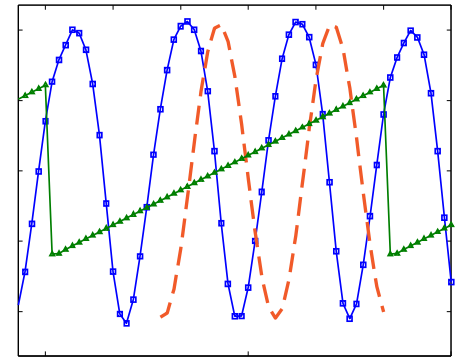


TES array

# Microwave SQUID Multiplexing ( $\mu$ mux) Concept

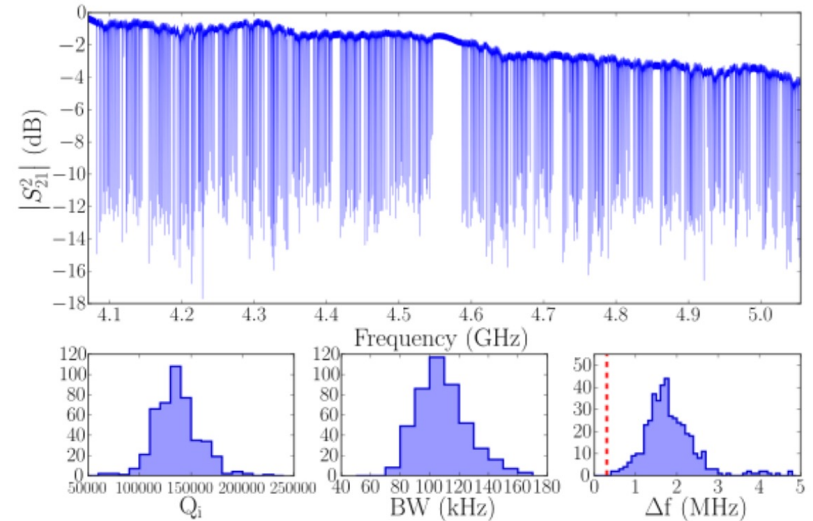
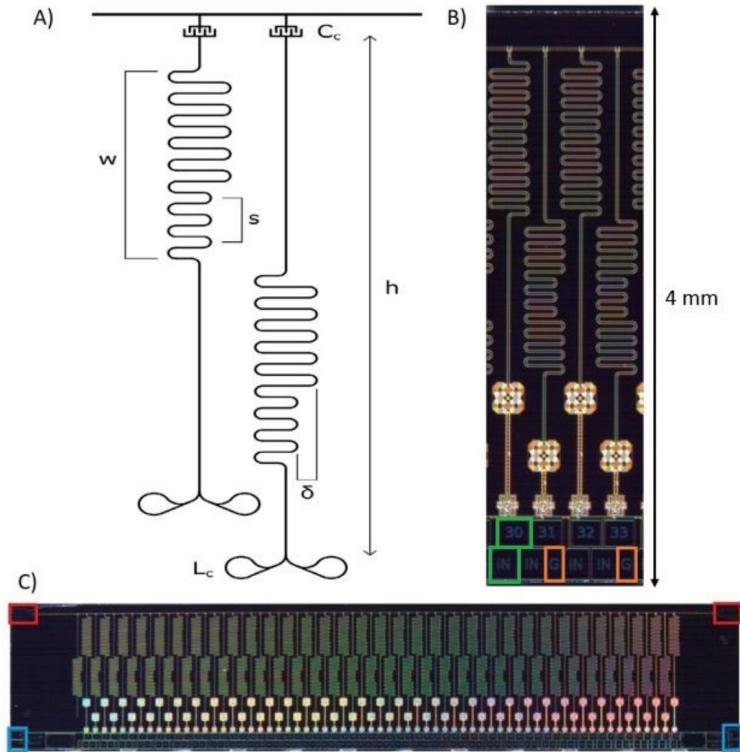


Flux Ramp Modulation



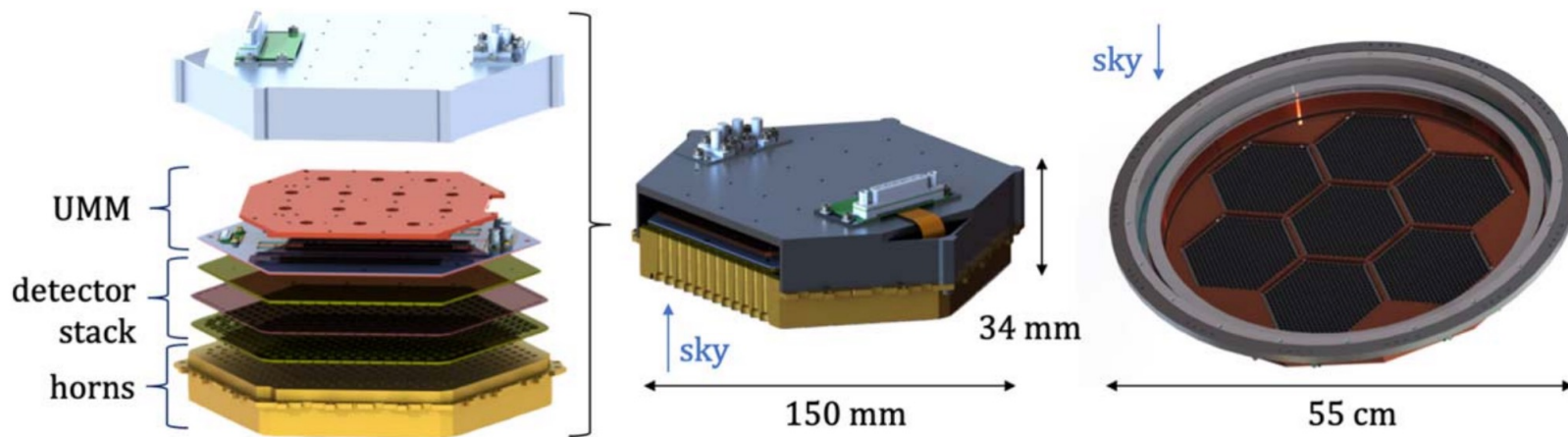
J.A.B. Mates Thesis (2011)

# $\mu$ mux developed for bolometers



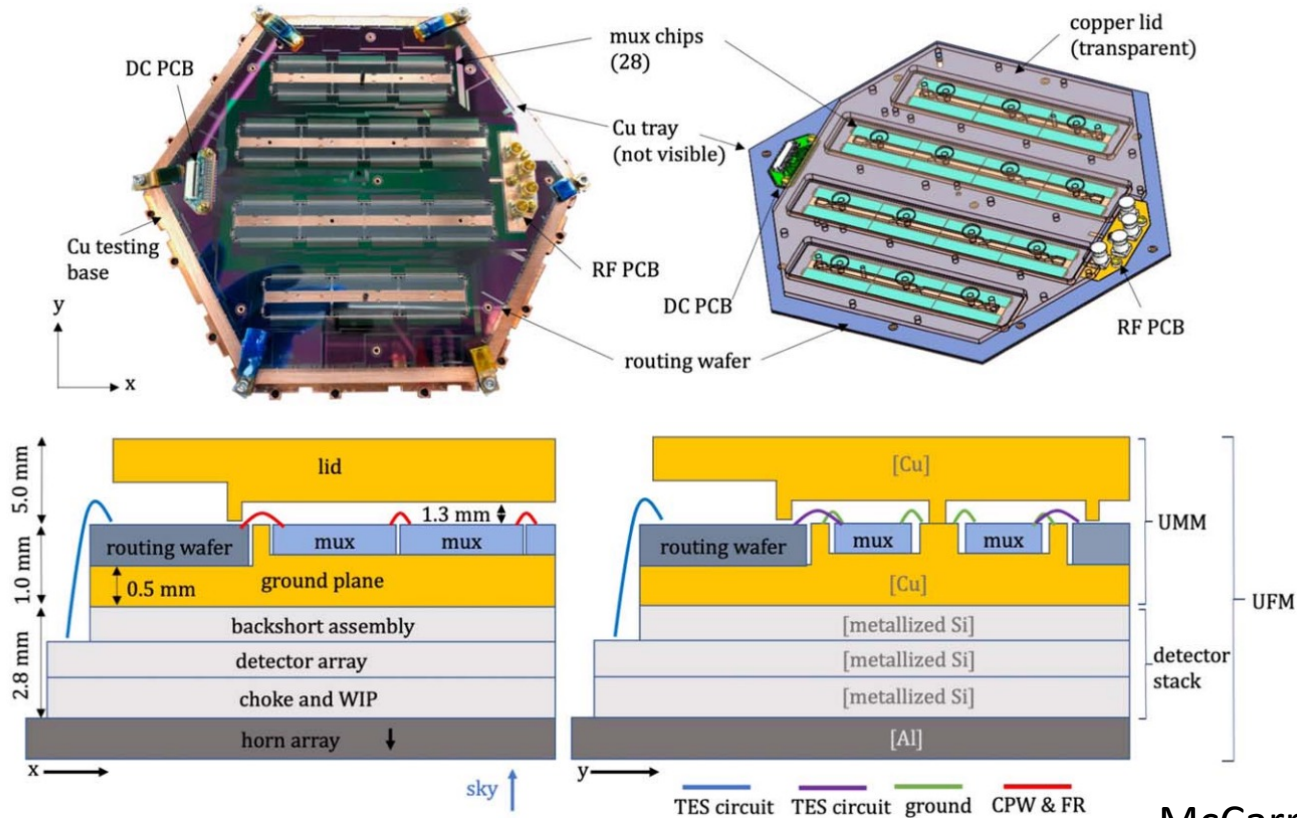
Dober et al 2021  
Scalability of 4000 channels in 4-8 GHz

# Implementation for Simons Observatory



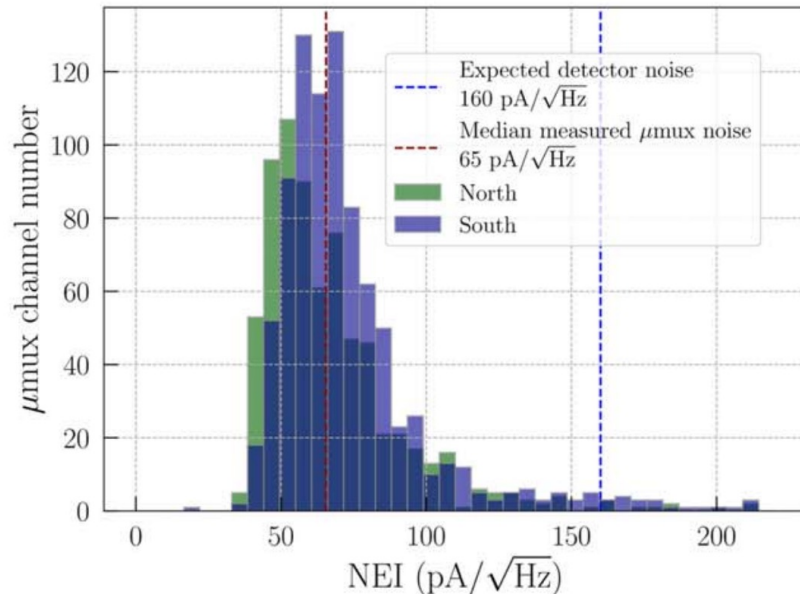
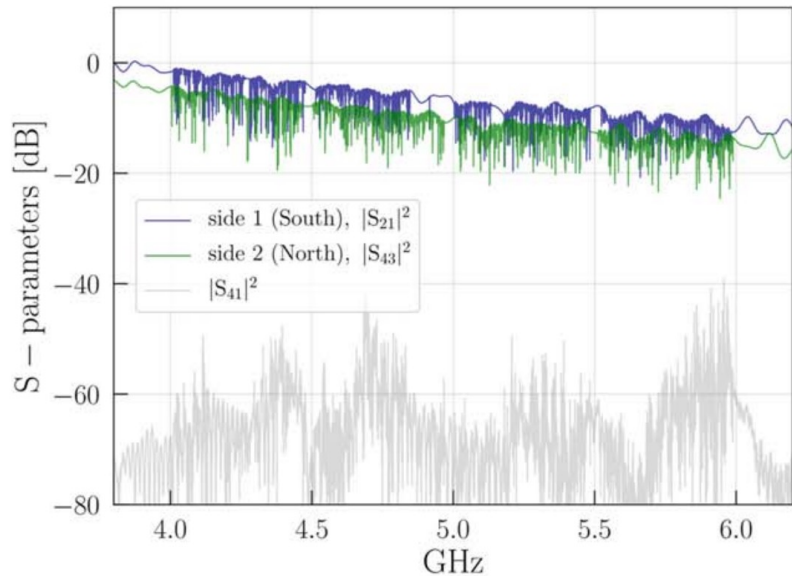
McCarrick et al 2021

# Implementation for Simons Observatory



McCarrick et al 2021

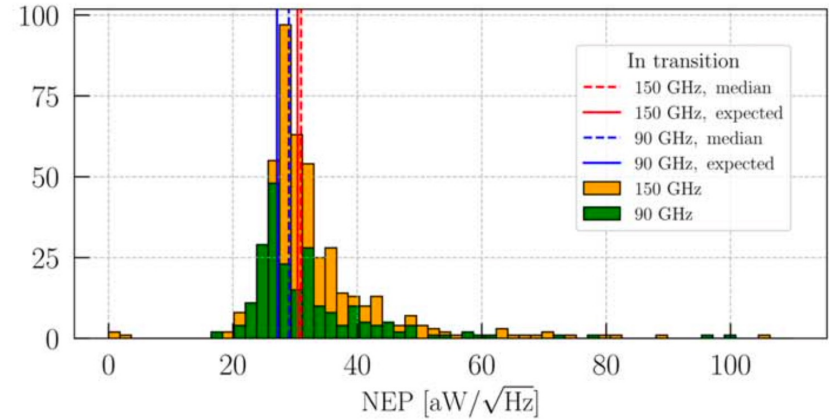
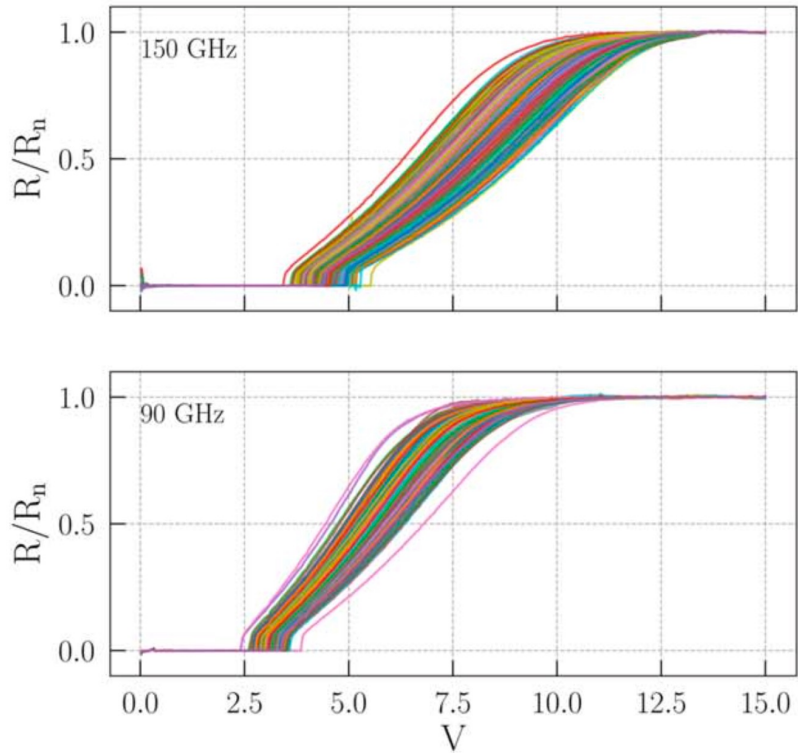
# Implementation for Simons Observatory



McCarrick et al 2021



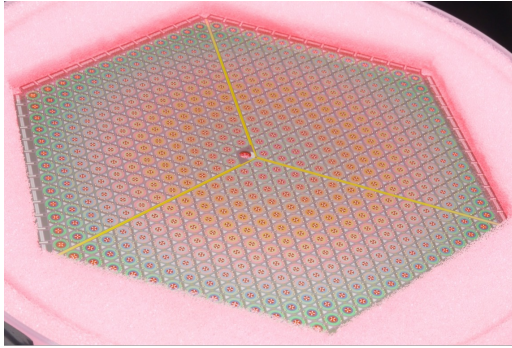
# Implementation for Simons Observatory



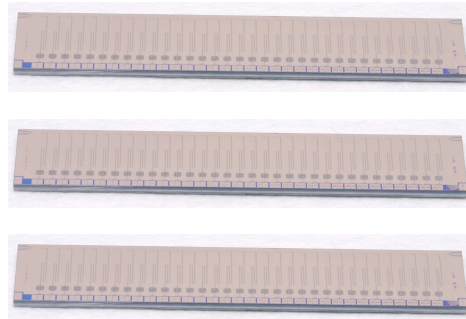
McCarrick et al 2021

# on-wafer multiplexing

TES array

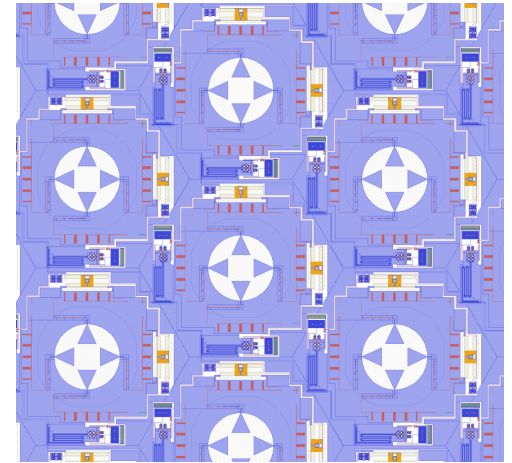


microwave SQUIDs



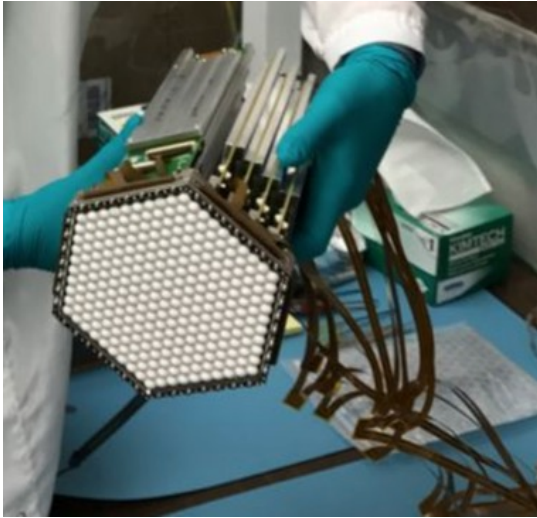
+

readout integrated into pixel

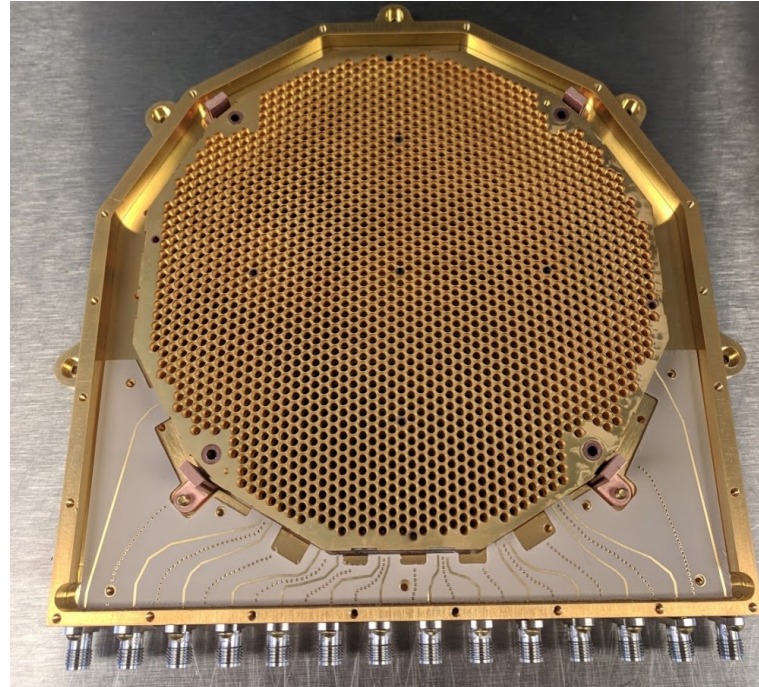


Number of interconnects on/off wafer reduce to 2 coax cables and few DC lines

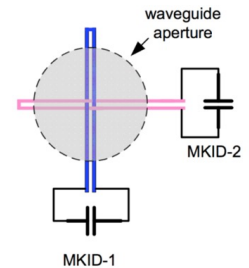
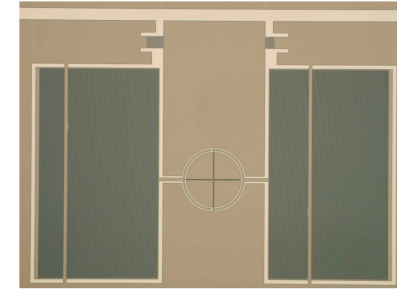
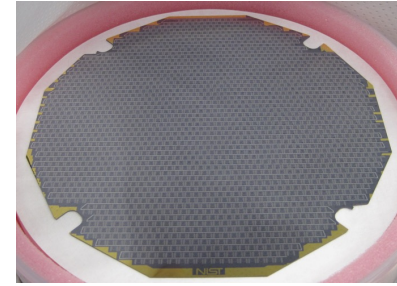
# MKID Motivation: Simplified Packaging



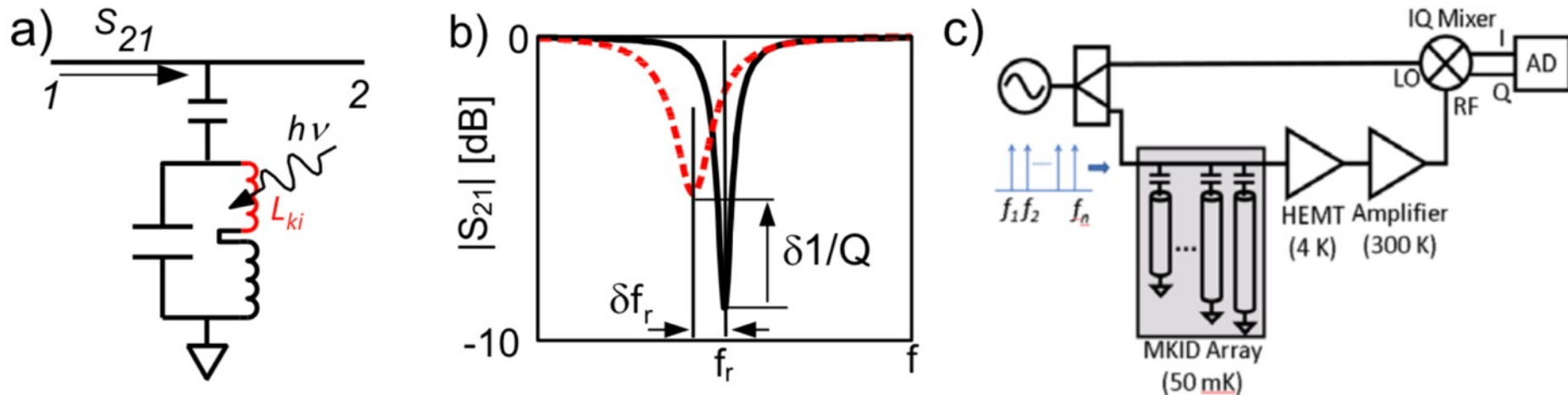
SPT-3G, Benson et al. 2014  
90/150/220 GHz, 1626 TES



TolTEC, Austermann et al. 2018  
280 GHz, 4012 MKIDs



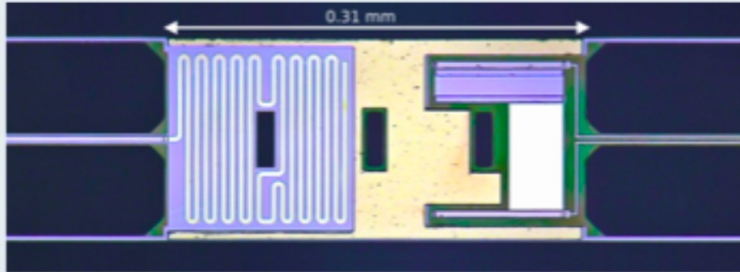
# Microwave Kinetic Inductance Detectors (MKIDS)



- First demonstration Day et al. 2003
- Power transduces frequency (or amplitude) shift in RF or microwave resonator

# Sensor Comparison

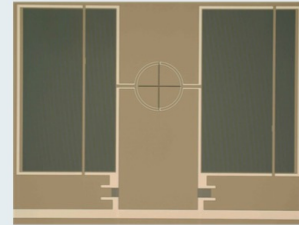
## TES Bolometers



Caltech/JPL

- Thermal detector
- Workhorse CMB sensor for last decade (~30,000 currently deployed)
- Fundamental detector noise source: phonon noise
- Mapping speed degrades as  $A \times \frac{kT_c}{h\nu}$

## MKIDs

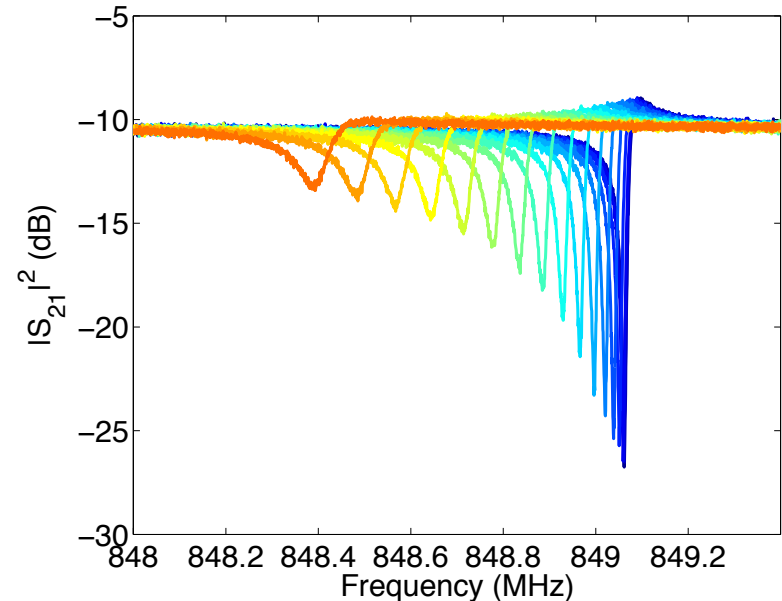


NIST

- Non-equilibrium pair-breaking detector
- Gaining momentum for CMB application
- Fundamental detector noise source: generation-recombination noise
- Mapping speed degrades as  $B \times \frac{\Delta}{h\nu}$

# MKID motivation: simplified characterization

- Microwave transmission sweeps
  - vs temperature
  - vs microwave power
- Full array characterization can be very quick

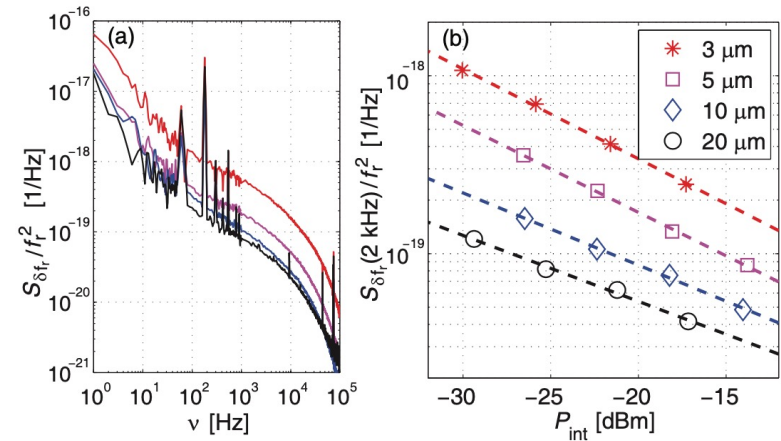


# From my hilarious colleague Jiansong Gao



# Why aren't we using MKIDs for CMB?

- Low frequency noise
- GR noise
- Multichroic MKID demonstration at CMB frequencies
- On-sky end-to-end demonstration

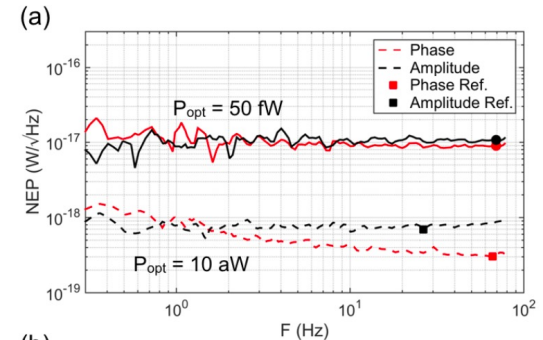


Gao thesis 2008

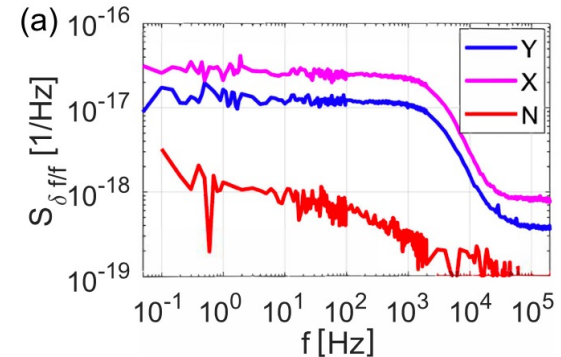


# Why aren't we using MKIDs for CMB?

- Low frequency noise
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- On-sky end-to-end demonstration



Baselmans et al. A&A 601 (2017)

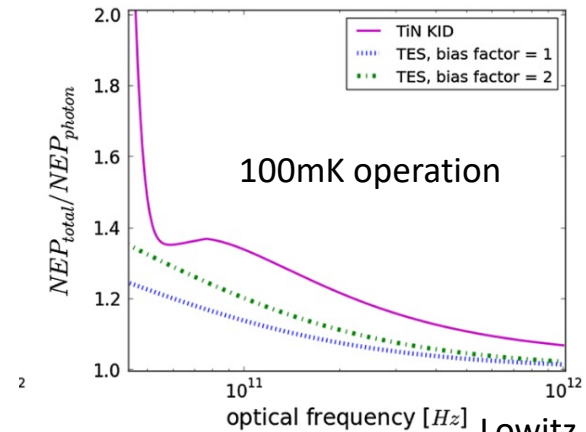


Vissers et al APL 2020

# Why aren't we using MKIDs for CMB?

- Low frequency noise
- GR noise
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- On-sky end-to-end demonstration

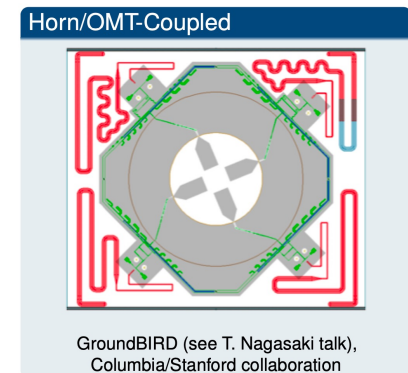
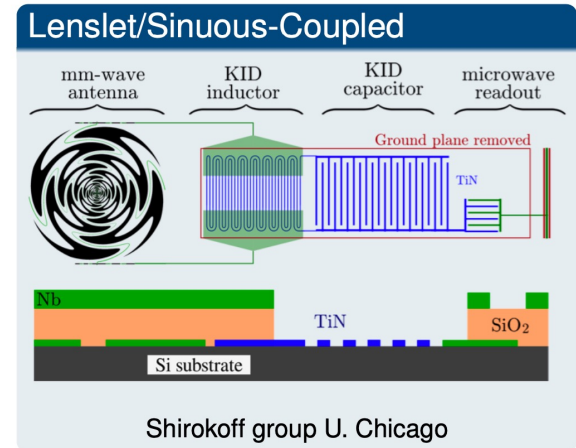
- Generation-recombination noise decreases sensitivity
- Mitigated by making superconducting gap many times lower than the photon energy.
- For lower frequencies places a constraint on  $T_{\text{bath}}$  to avoid thermal GR noise.
- Does this practically mean mixed technology focal plane for instruments with frequency coverage  $< 100$  GHz?



Lowitz et al 2014

# Why aren't we using MKIDs for CMB?

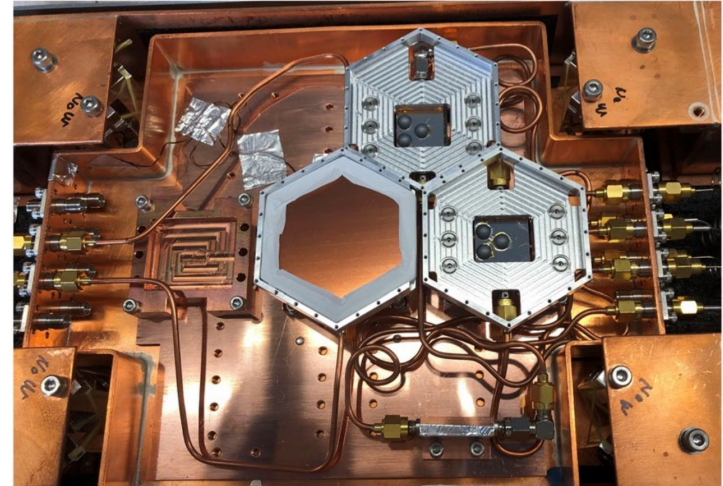
- Low frequency noise
- GR noise
- Multichroic MKID demonstration at CMB frequencies
- On-sky end-to-end demonstration



# Why aren't we using MKIDs for CMB?

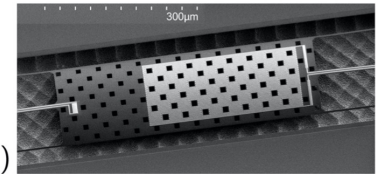
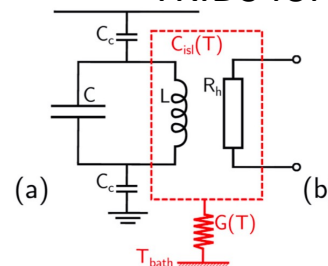
- Low frequency noise
- GR noise
- Multichroic MKID demonstration at CMB frequencies
- On-sky end-to-end demonstration

GroundBIRD



Lee et al. 2020

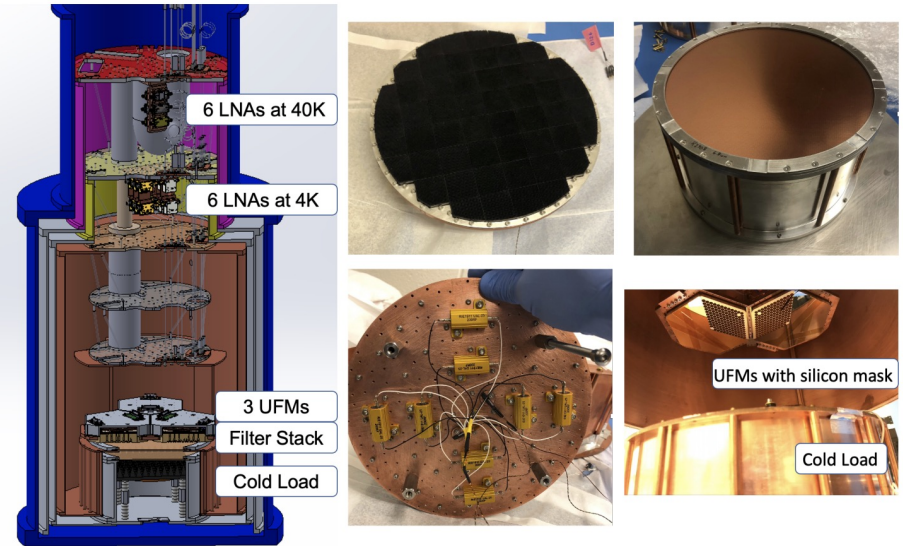
TKIDs for BICEP Array?



Wandui et al 2020

# Challenge #3: Array Characterization

- Characterization of arrays extremely challenging
  - 100mK cryogenics
  - Large mm-wave windows
  - different configurations desirable requiring multiple cooldowns
- Historically this can take months for one array
- Requires well-understood, well-calibrated cryogenic test platforms

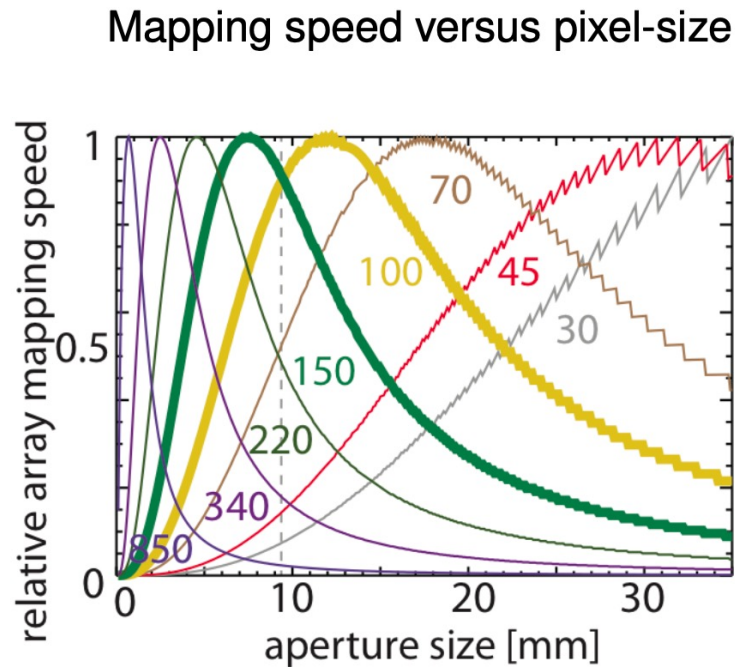
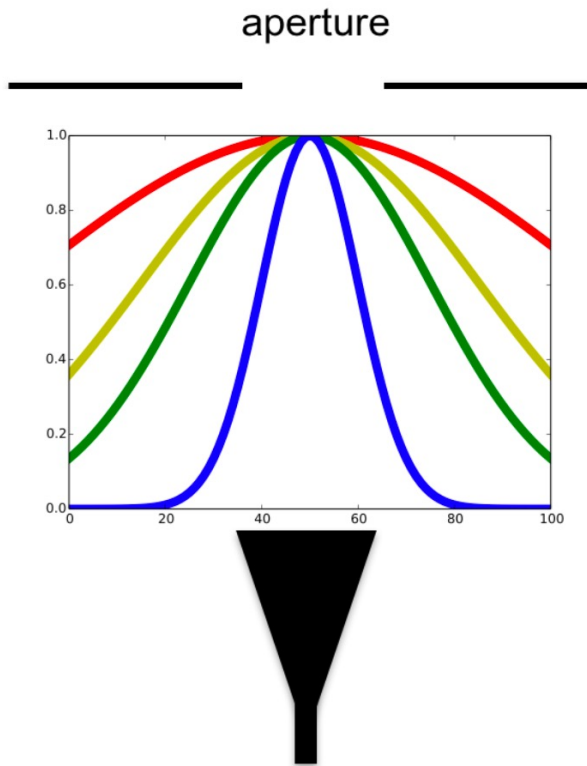


Wang et al submitted to JLTP

# New ideas for space implementation

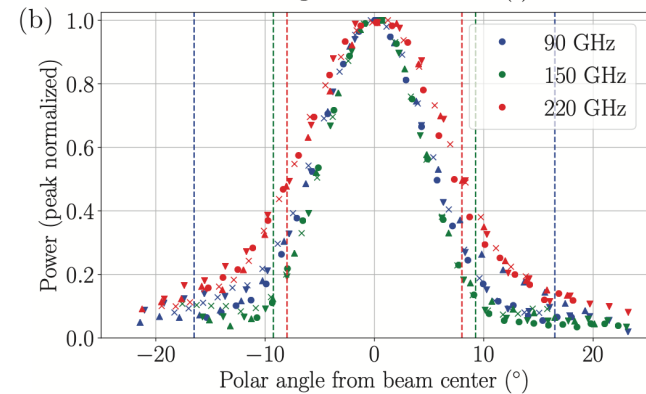
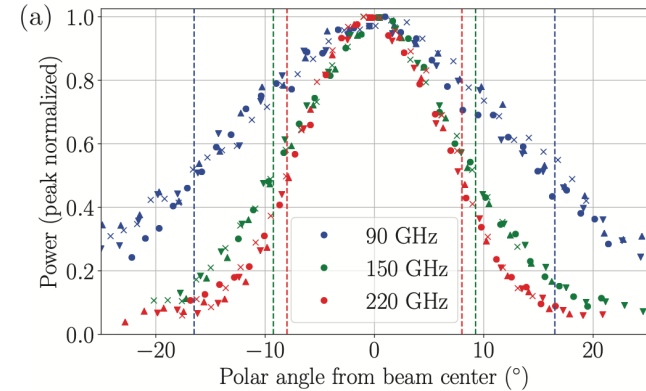
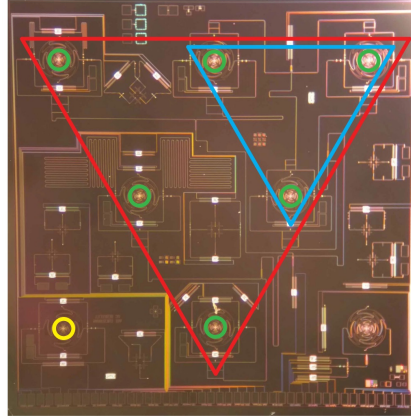
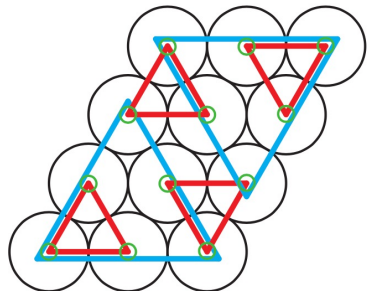
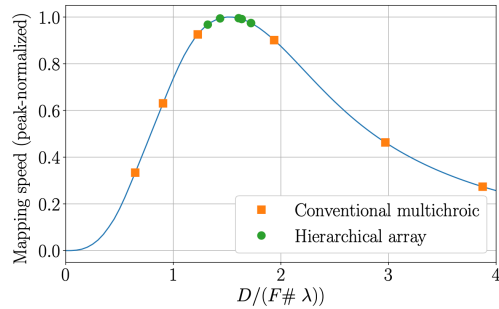
- Hierarchical phased arrays
- on-chip refrigerators

# Single diffracting aperture leads to inefficiently



Datta et al. (2014)

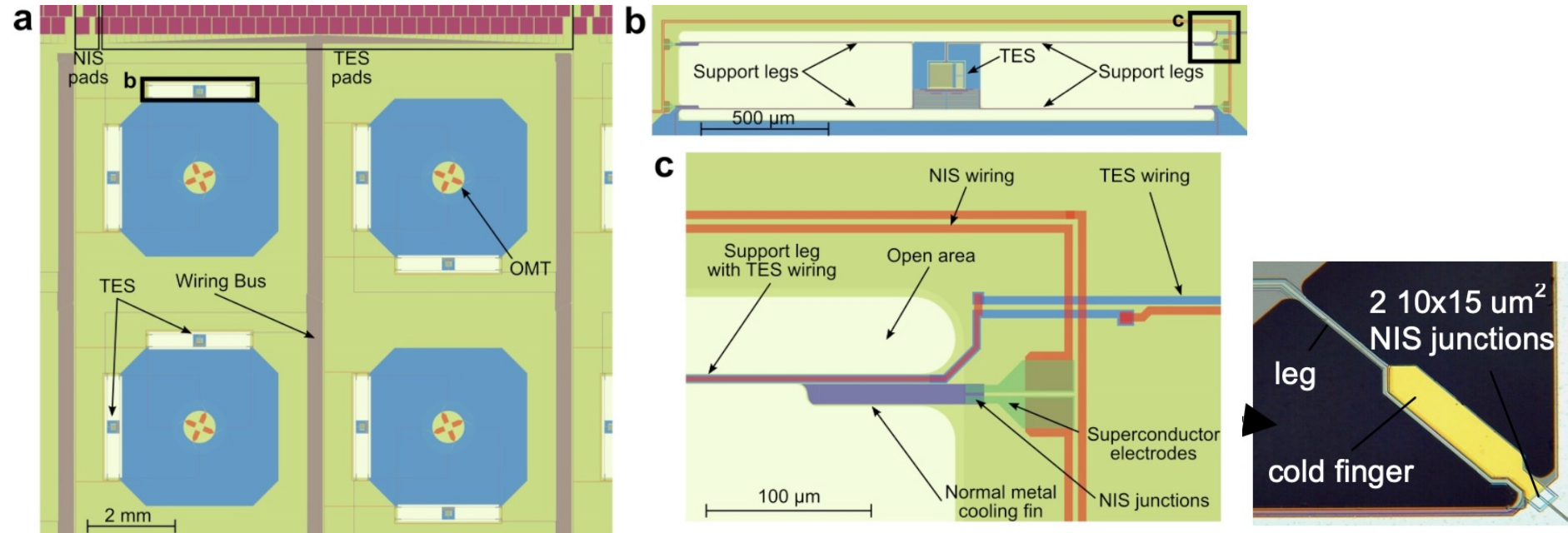
# Heirarchical phased arrays



Cukiermann et al 2018



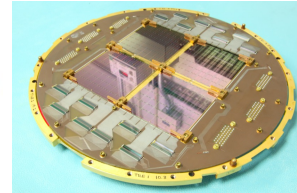
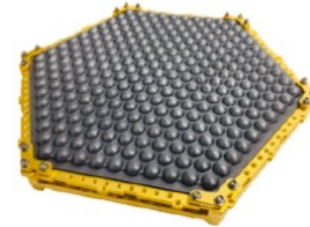
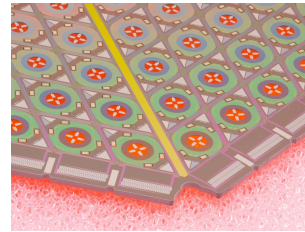
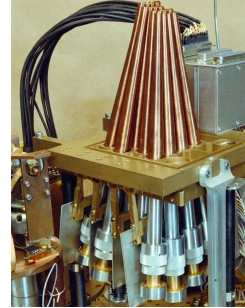
# on-bolometer coolers



100mK TES performance with 300mK refrigeration techniques

# Final thoughts

- Last two decades saw tremendous innovation in superconducting sensors for CMB detection
- For the next decade, need more of today's state-of-the-art but faster, easier to install, reliable. This is a phase change for the field. It will be realized with healthy collaboration
- What we have developed for the ground will be deployed in space.
- The shape of CMB focal planes to come? Plenty of innovative ideas out there. Given landscape, where to put focus?



??

# Many Thanks!

- Special thanks to the organizers
- [hubmayr@nist.gov](mailto:hubmayr@nist.gov)
- <https://www.nist.gov/programs-projects/long-wavelength-detectors-and-applications>

